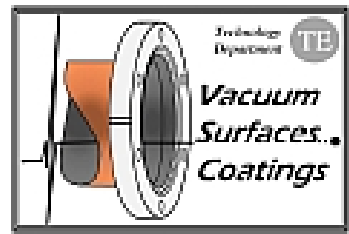


BGC “v3” design & integration

CERN TE-VSC

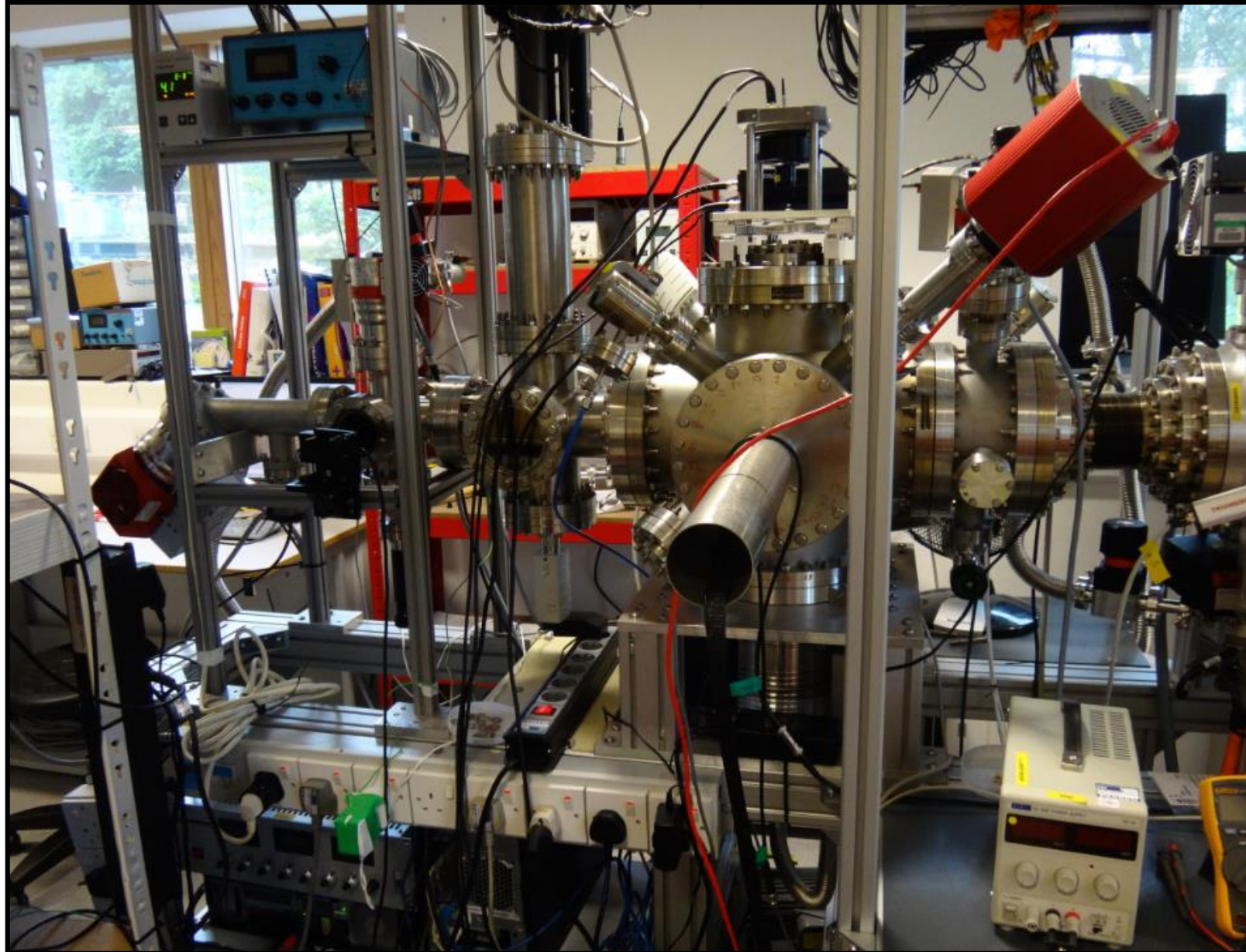
Marton Ady / Giuseppe Bregliozzi / Eric Page

BGC review meeting, CERN, 27.11.2018



Context

“v1” setup (past)



Context

- “v2” instrument currently assembled in Cockcroft institute

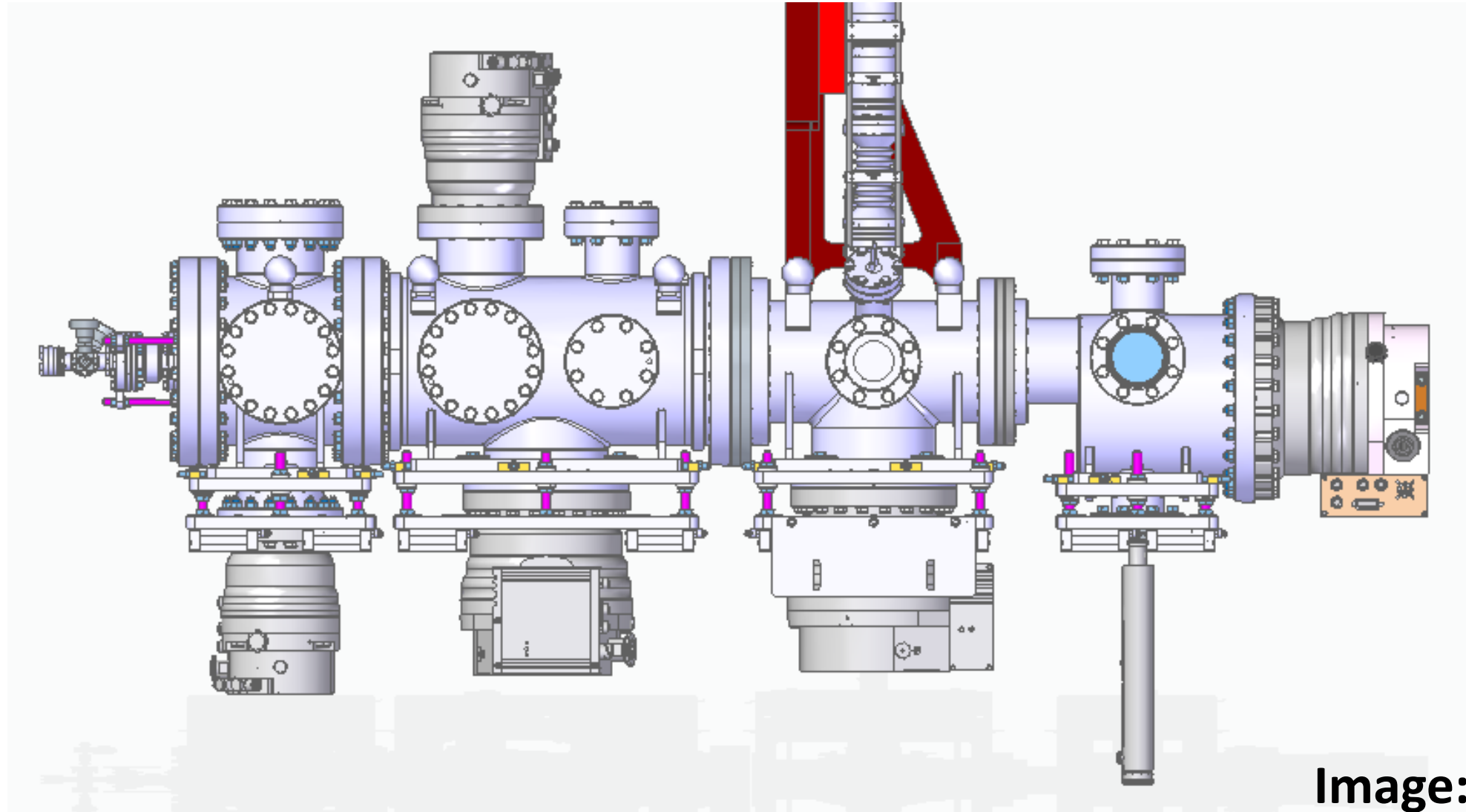
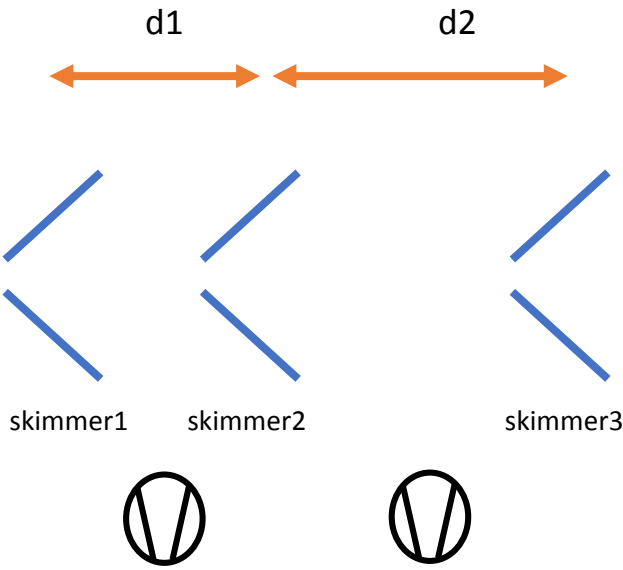


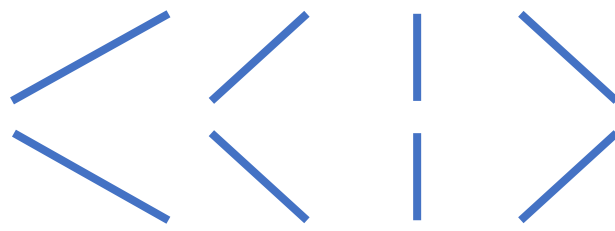
Image: Hao Zhang

From last review meeting

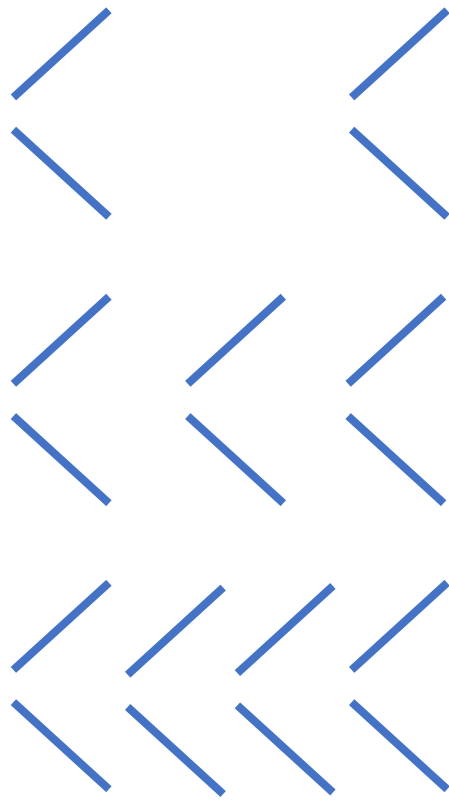
Free parameters, low pressure part



Distance between skimmers

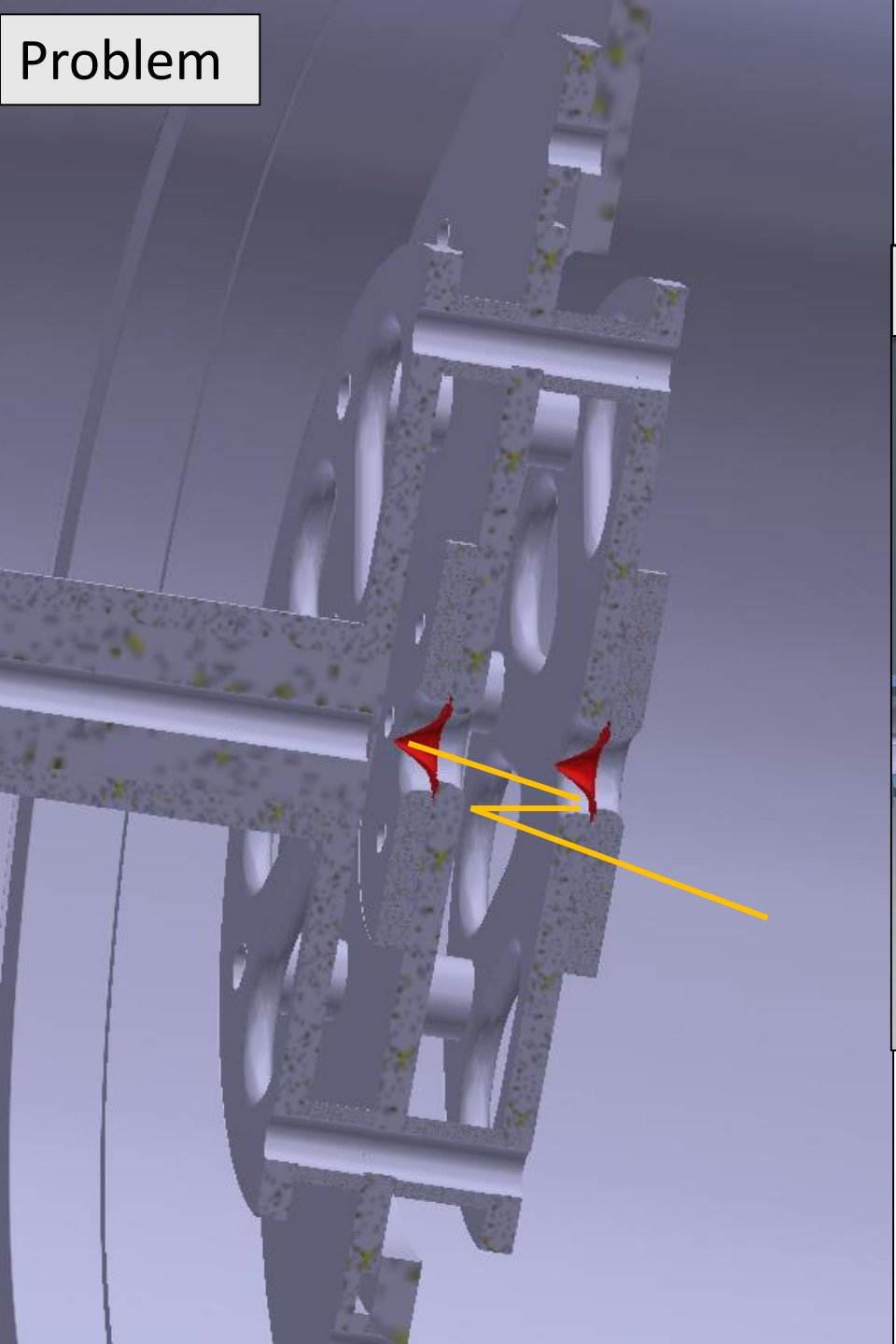


Skimmer shape



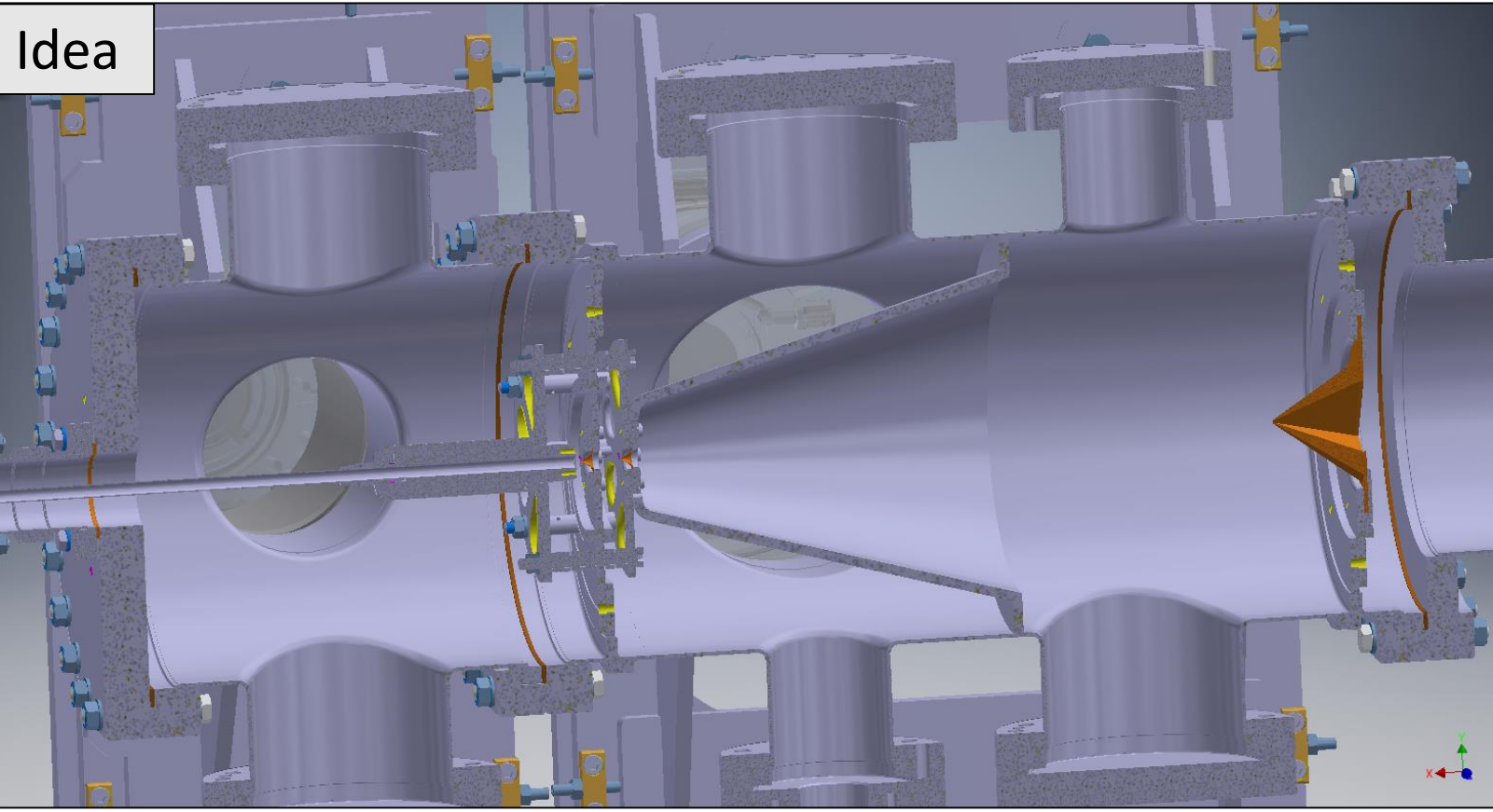
Number of skimmers

Problem



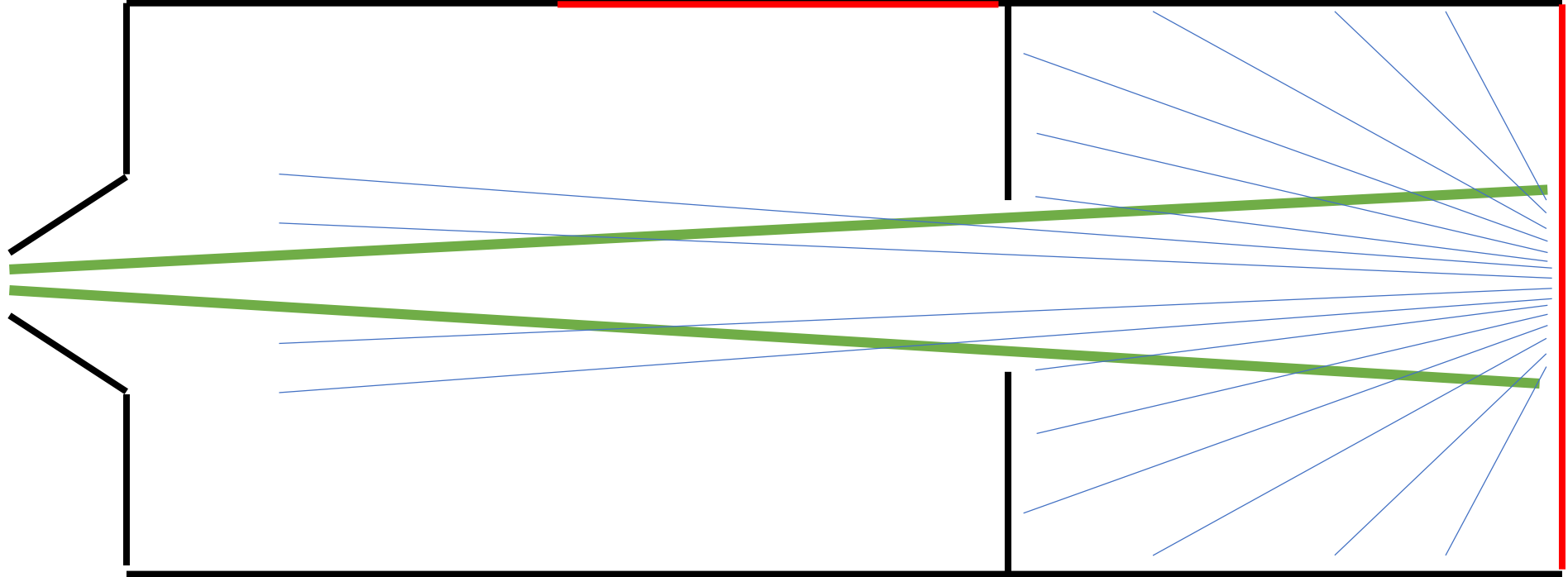
From last review meeting 5

Idea



From last review meeting

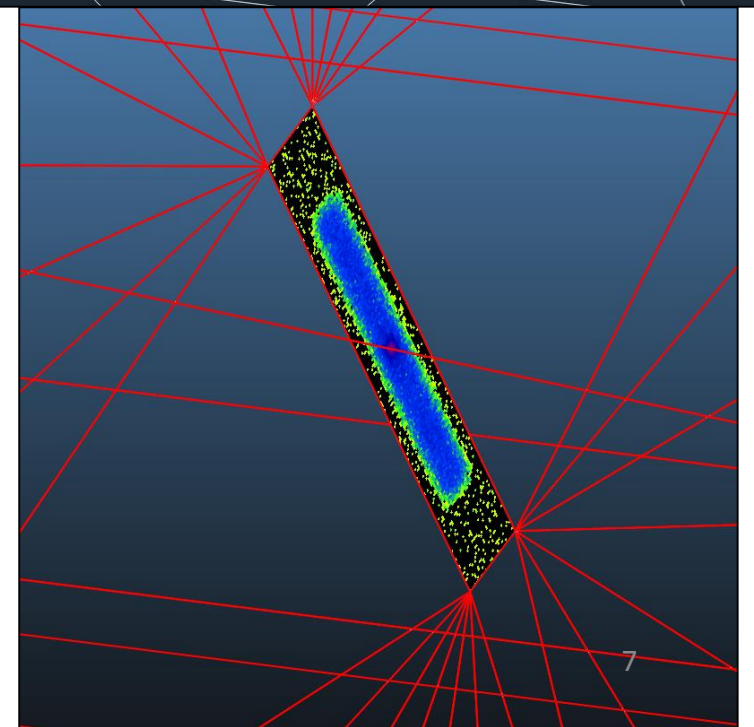
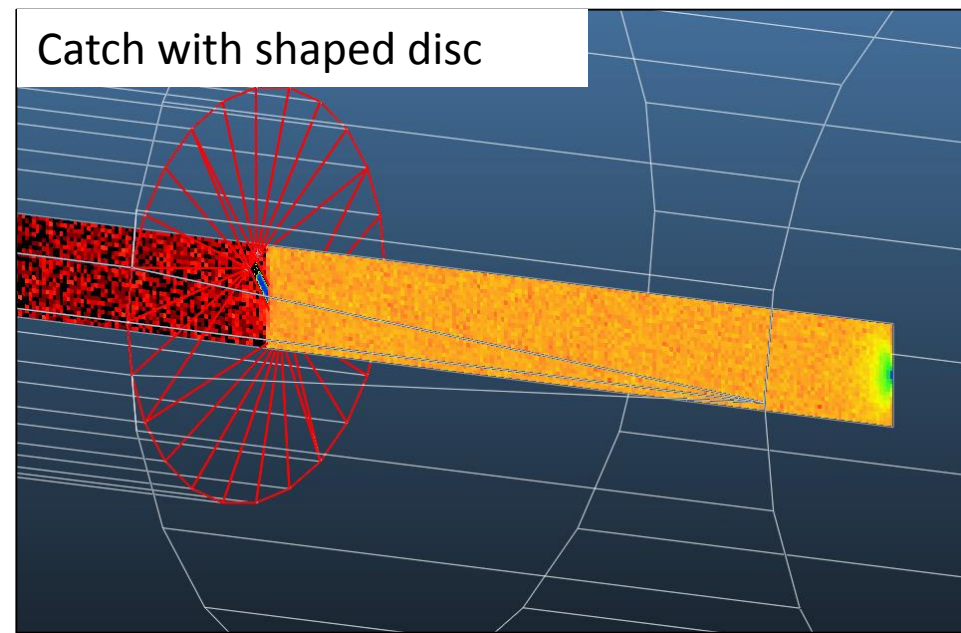
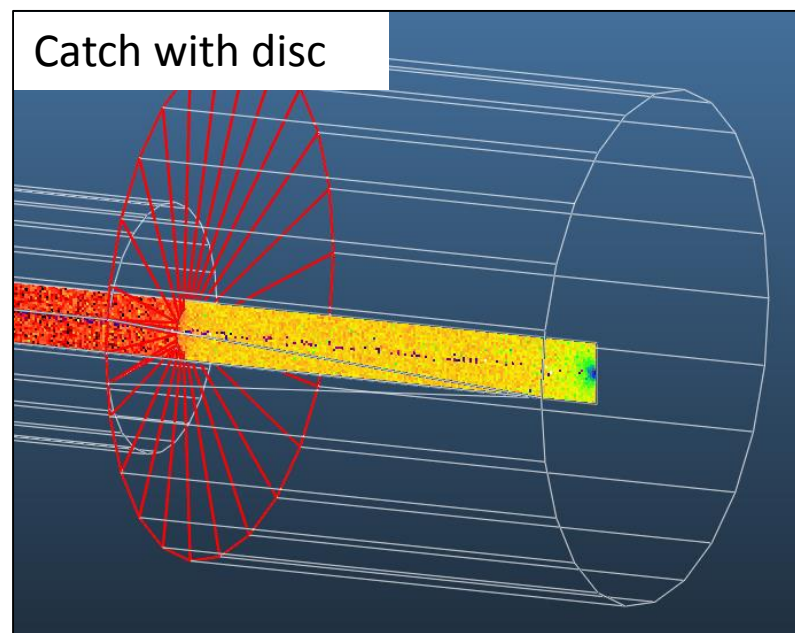
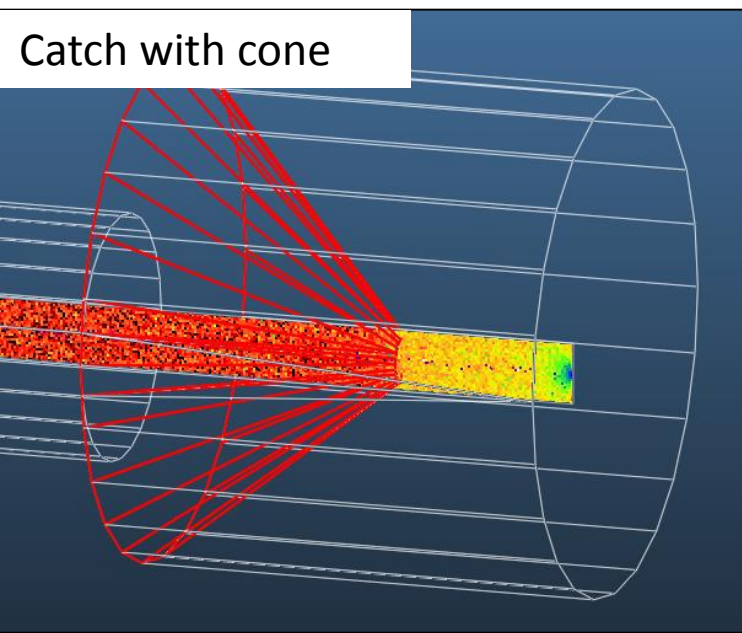
Backscattering reducer



Skimmer3

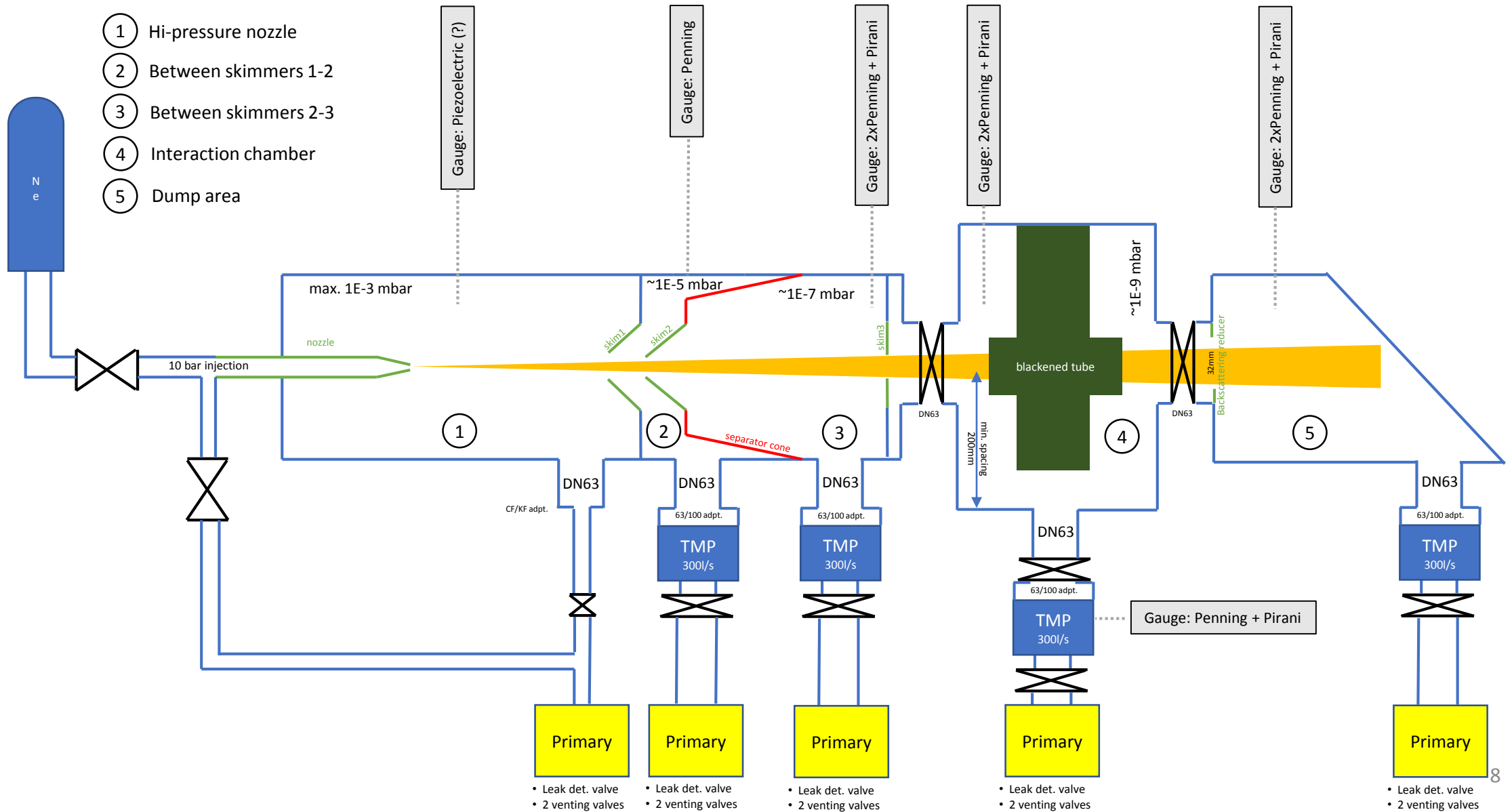
Interaction chamber

From last review meeting



Context

- “v3” instrument needs to be more compact (goes in the LHC)



DN100 gasket with 63 hole

I don't think DN160 gasket with 63 mm hole needed since there is 3 skimmer upstream

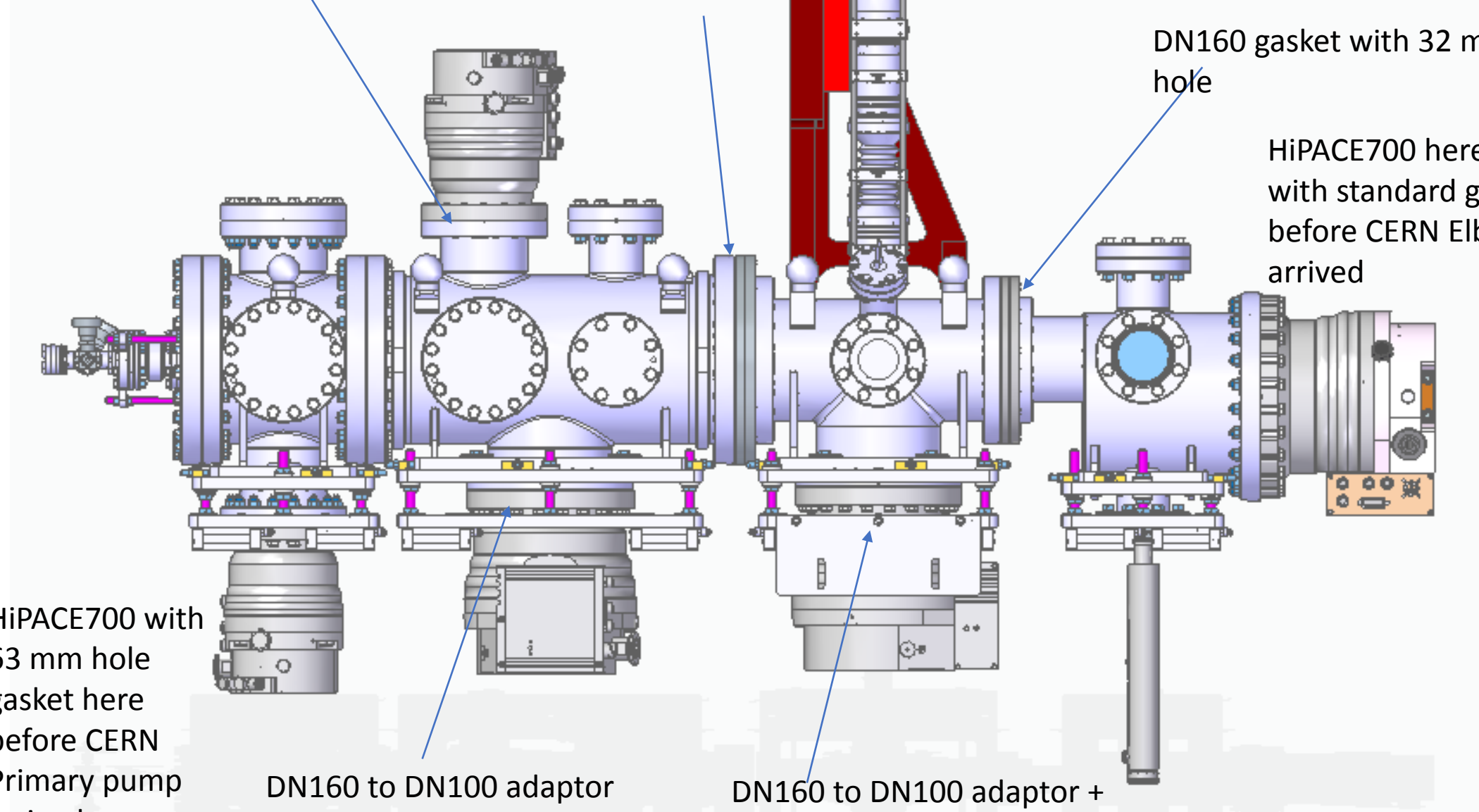
DN160 gasket with 32 mm hole

HiPACE700 here with standard gasket before CERN Elbow arrived

HiPACE700 with 63 mm hole gasket here before CERN Primary pump arrived

DN160 to DN100 adaptor + DN100 gasket with 63 hole + Hipace300

DN160 to DN100 adaptor + DN100 gasket with 63 hole + Hipace300



Simulation goals

- Look for a suitable “v3” design
- Understand pressure sensitivity to...
 - Changing gas jet size
 - Changing distances
 - Changing pump sizes
 - Using smaller valves
 - Adding “backscattering reducer”
 - Changing dump area
 - 90 deg. elbow
 - Pump offset
 - Pump tilting

One fix point: the interaction chamber

Interaction_BGC3

3_Origin

Part) BGC3 Support

Part) INTERACTION_VACUUM_VESSEL_BGC3

Part) BGC Geo Support

Part) DN100.1) VANNE VAT DN100 SERIE 48

Part) DN63.1) VANNE VAT DN63 SERIE 48

Part) DN63.2) VANNE VAT DN63 SERIE 48

Part) DN100 - UHV CF FIXED FLANGE STDVUFHV0009

Part) DN 63 - UHV CF FIXED FLANGE STDVUFHV0007

Part) DN 63 - UHV CF FIXED FLANGE STDVUFHV0007

Part) DN1.1) Vacuum Gauge SCEM 18.40.30.330.9

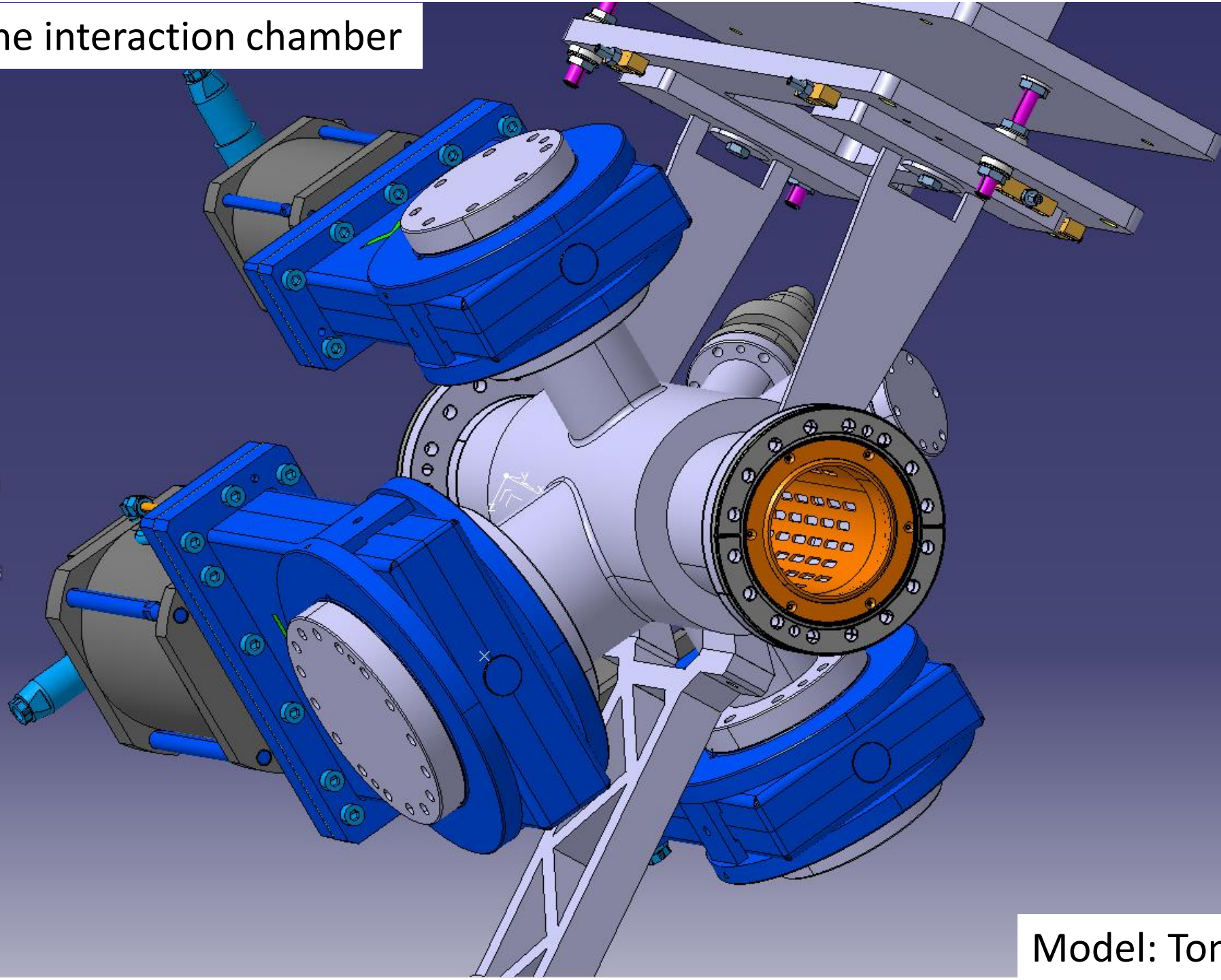
Part) DN1.1) DN 40 - UHV CF FIXED FLANGE STDVUFHV0005

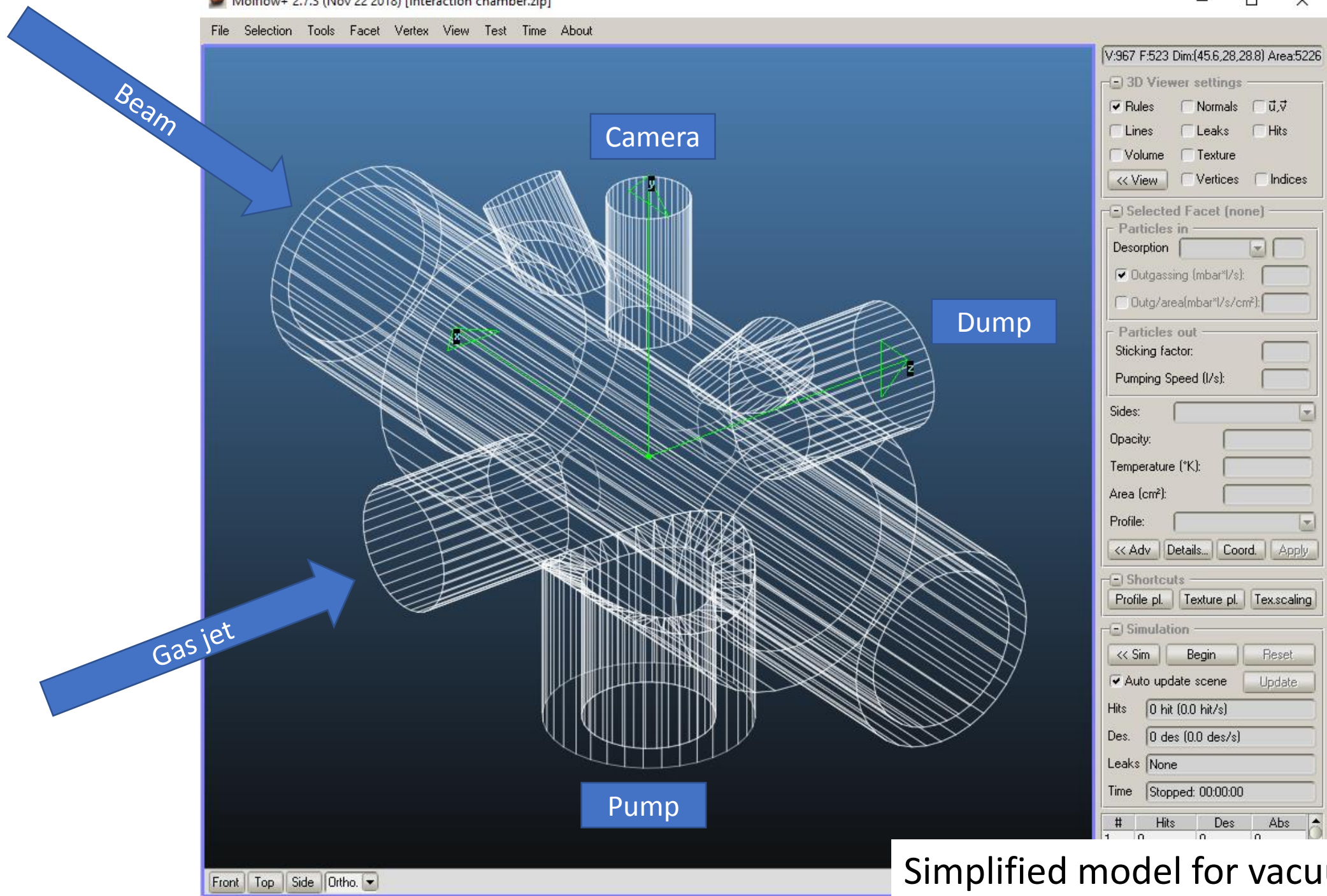
Part) DN1.1) VIEWPORT DN40 CF

Part) _Volume

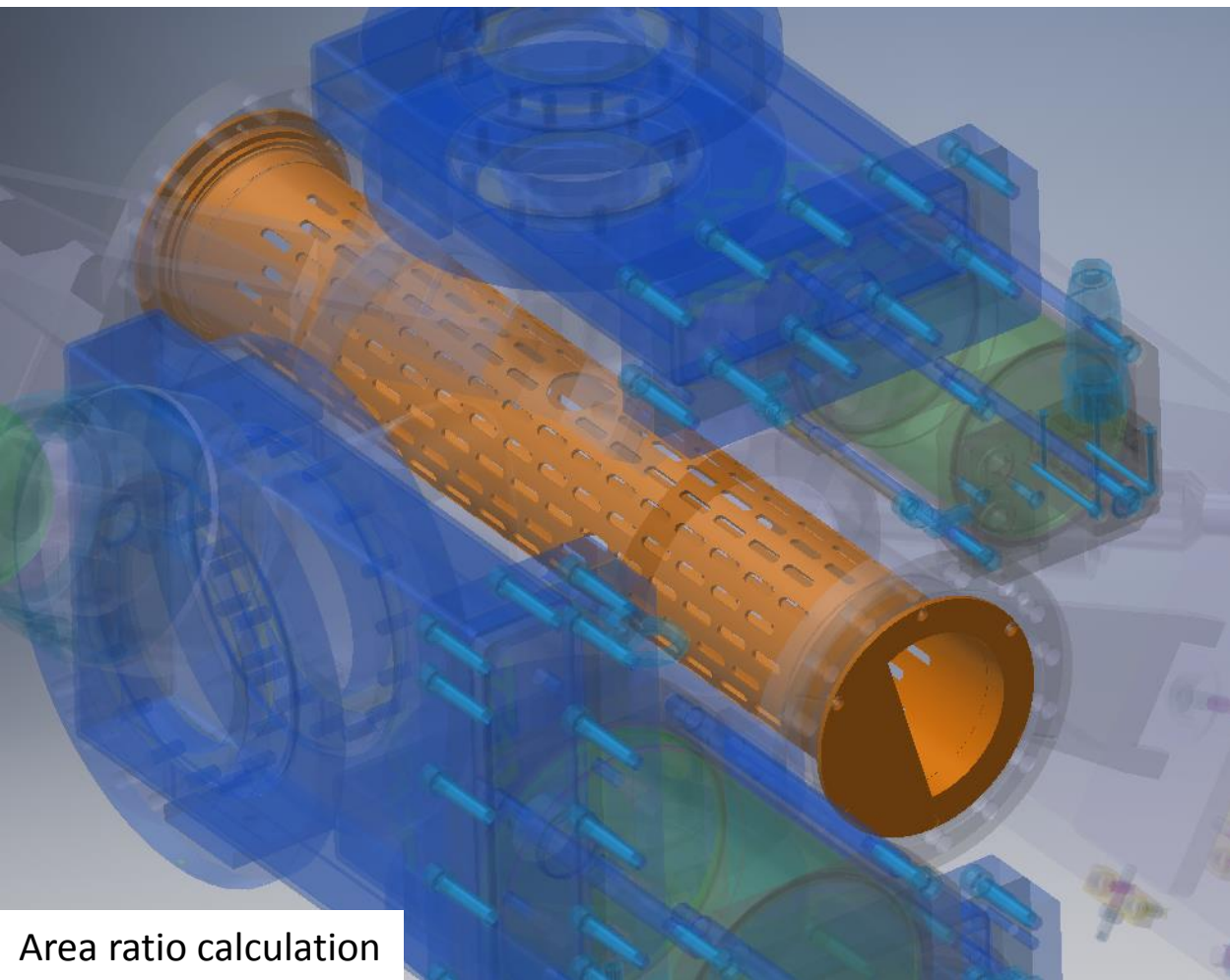
Part) DN1.1) BGCOptic

Part) DN1.2) BGCAAlignment

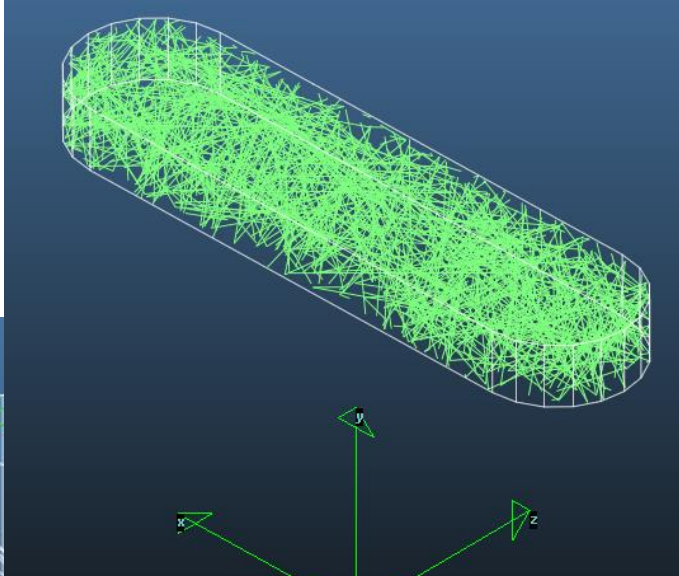
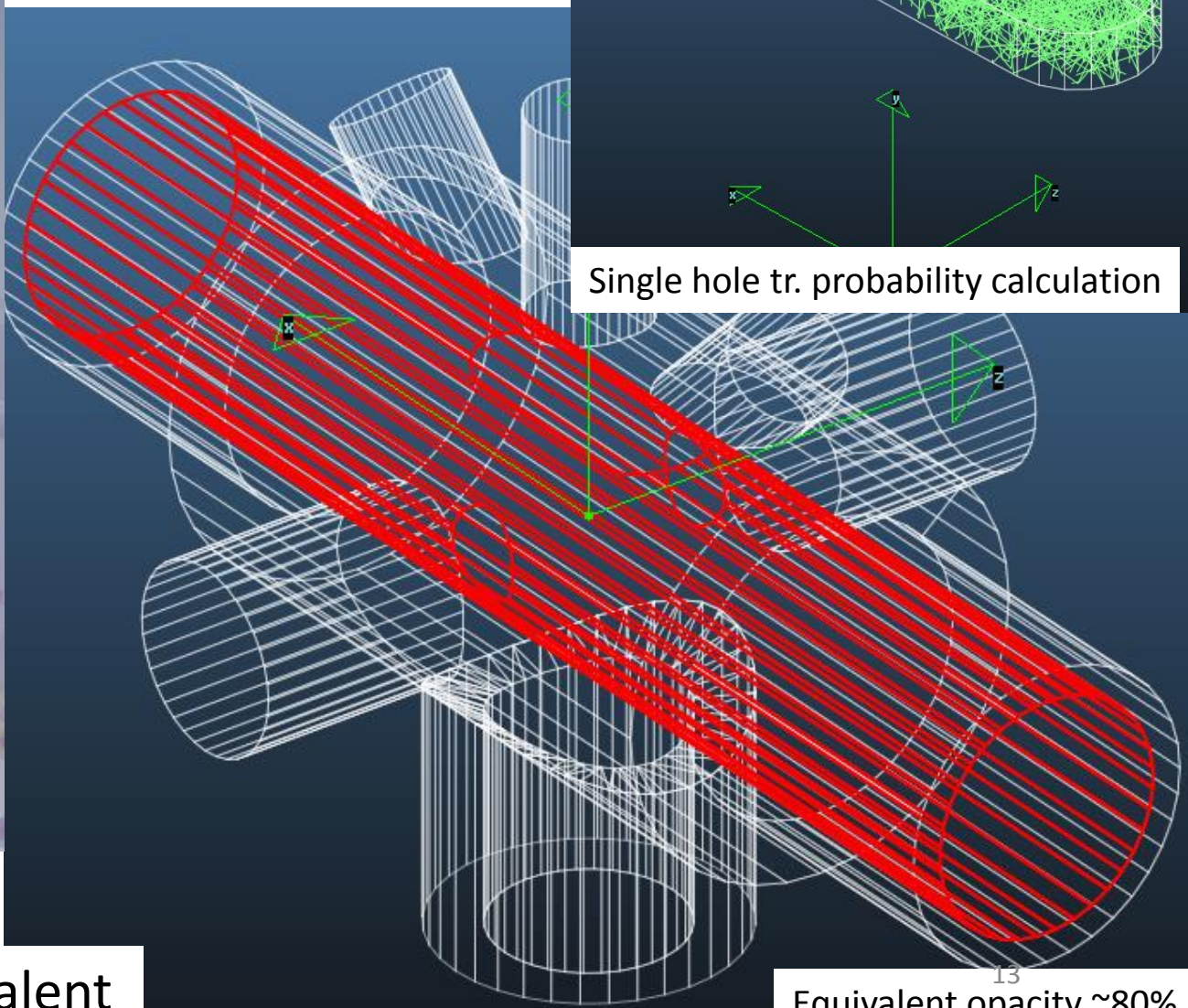




Simplified model for vacuum simulation¹²



Area ratio calculation

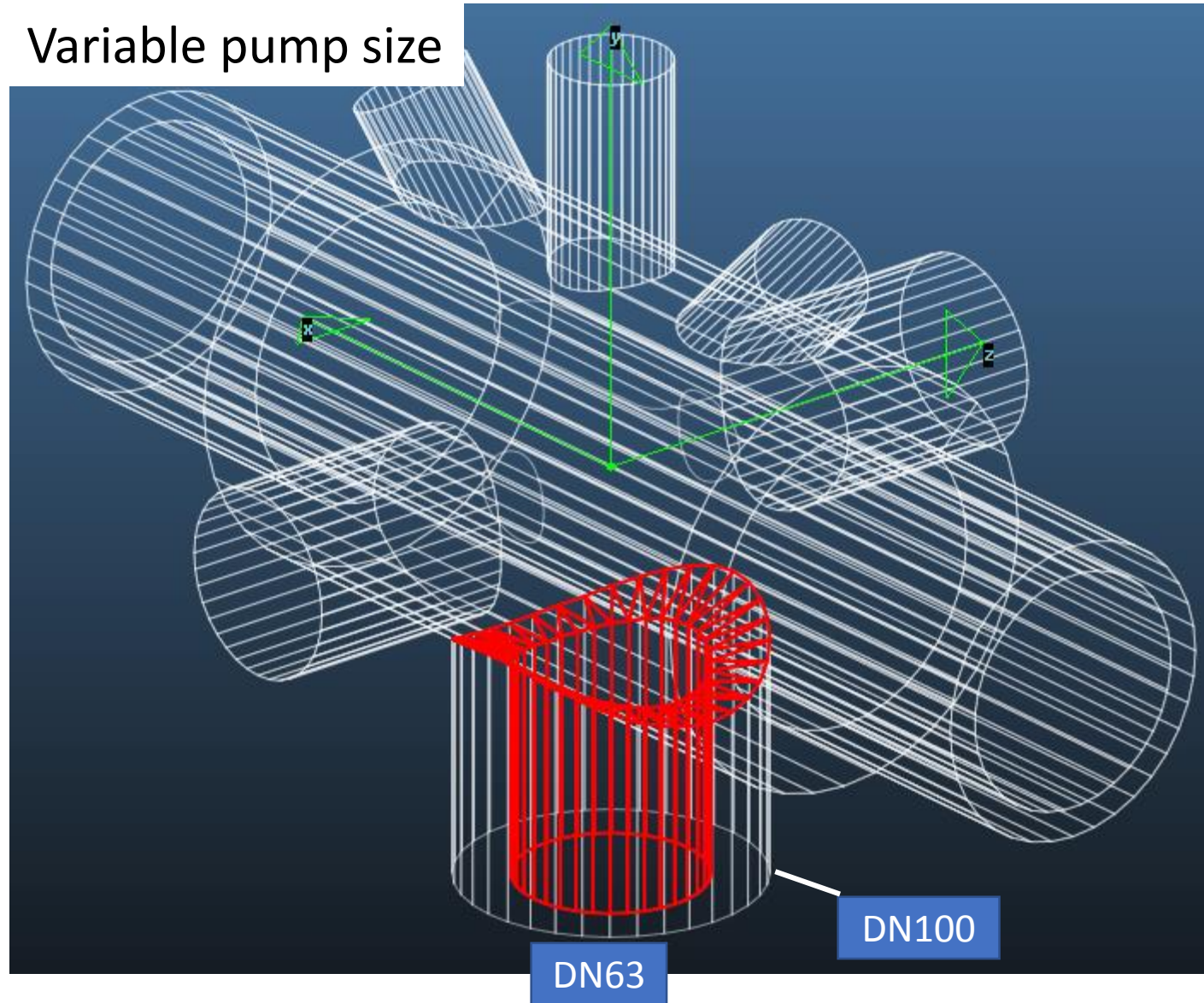


Single hole tr. probability calculation

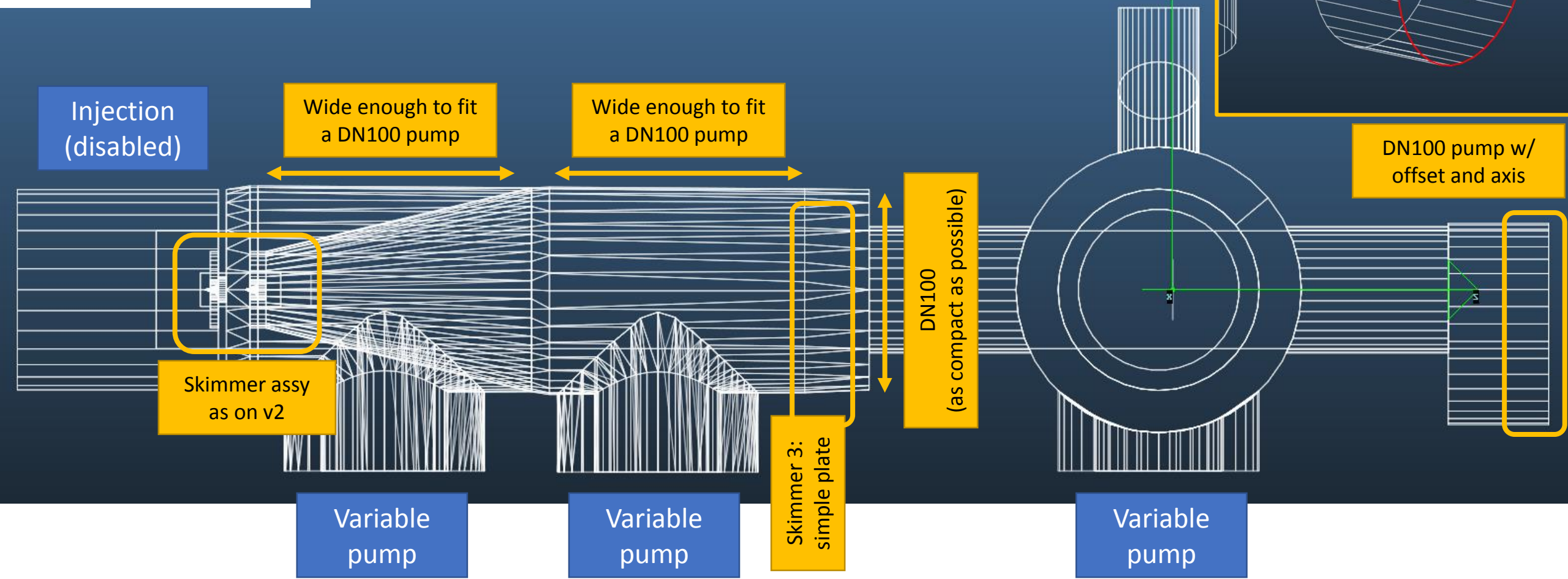
Replacing impedance insert with vacuum equivalent

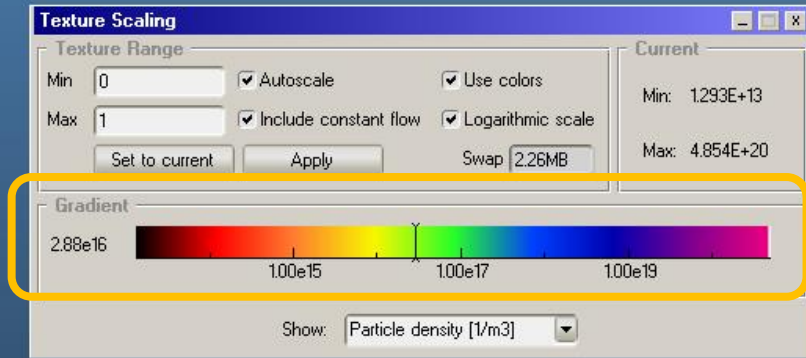
Equivalent opacity ¹³ ~80%

Variable pump size

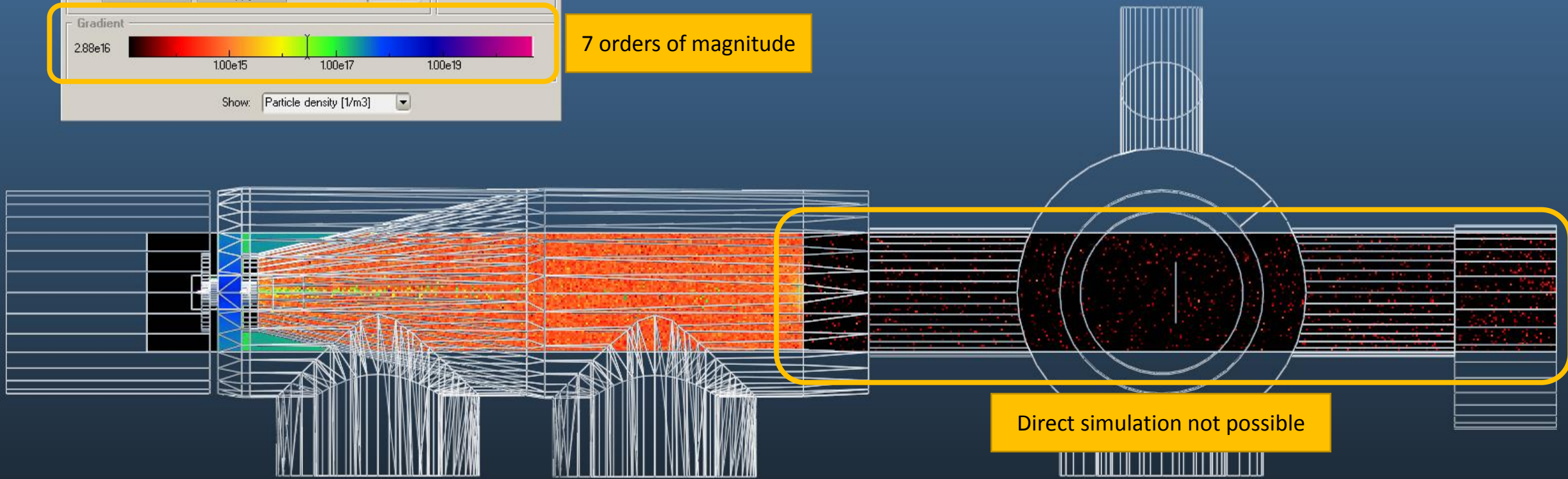


First "v3" attempt

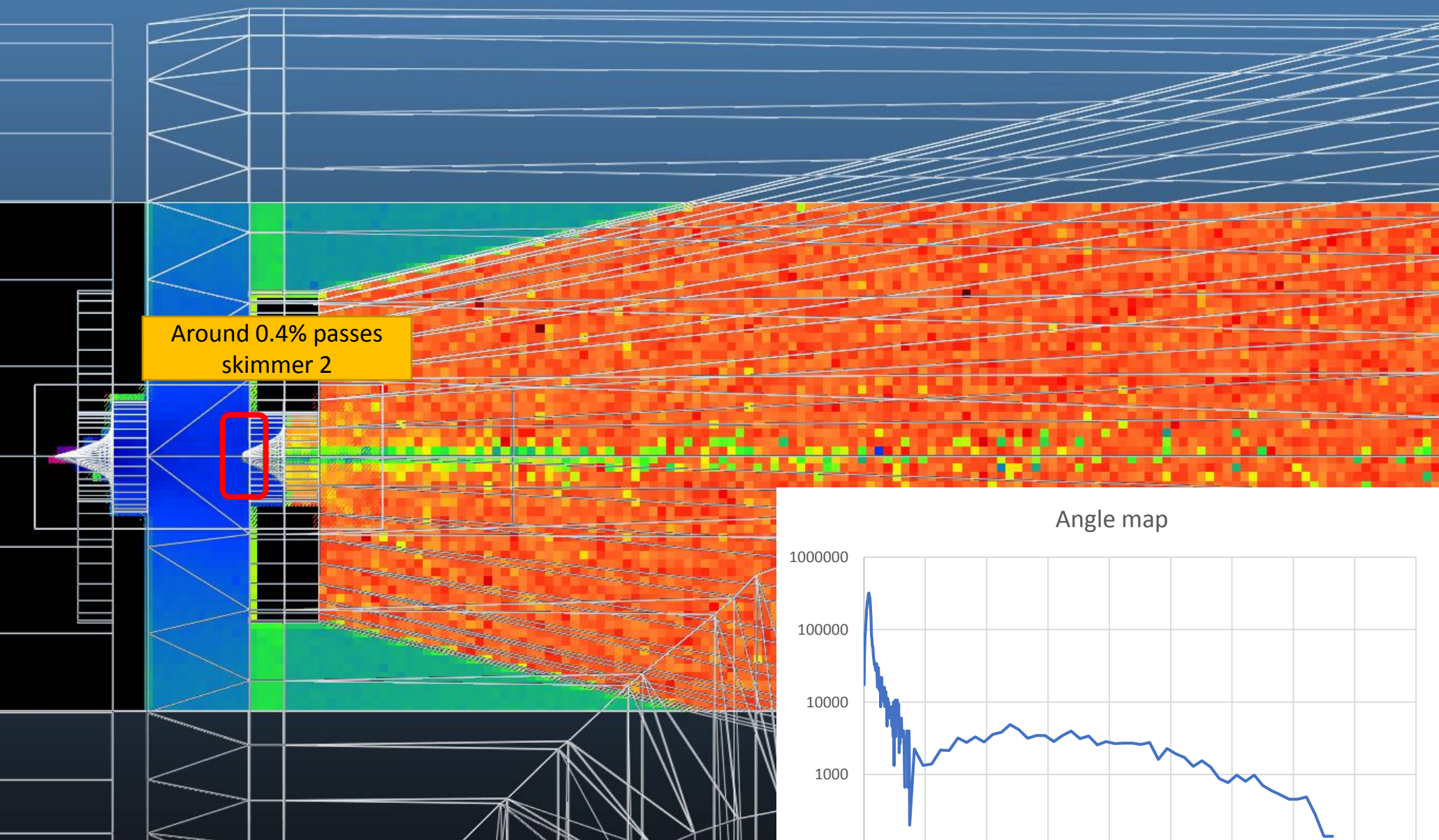




7 orders of magnitude



Iterative simulation 1st step: record angular distribution on skimmer 2



Advanced facet parameters

Texture properties

- Enable texture Force remesh
- Resolution: cells/cm cm/cell
- Count desorption Count reflection
- Count absorption Count transparent pass
- Angular coefficient Record direction vectors

Texture cell / memory

Memory: 0 bytes Cells: 0

Additional parameters

Reflection: 1 part diffuse, 0 part specular,
 0 part cosine^ 0

Accommodation coefficient: 1

Teleport to facet: 0

Structure: 2 Link to: no

- Moving part
- Wall sojourn time Info

Attempt freq: 1e+13 Hz Binding E: 100 J/mole

View settings

- Draw Texture Draw Volume <- Change draw

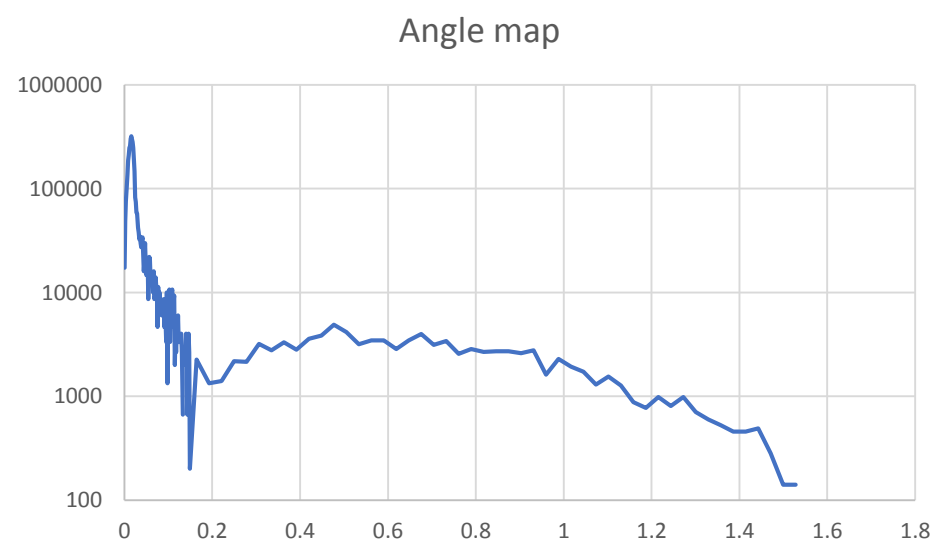
Dynamic desorption

Incident angle distribution

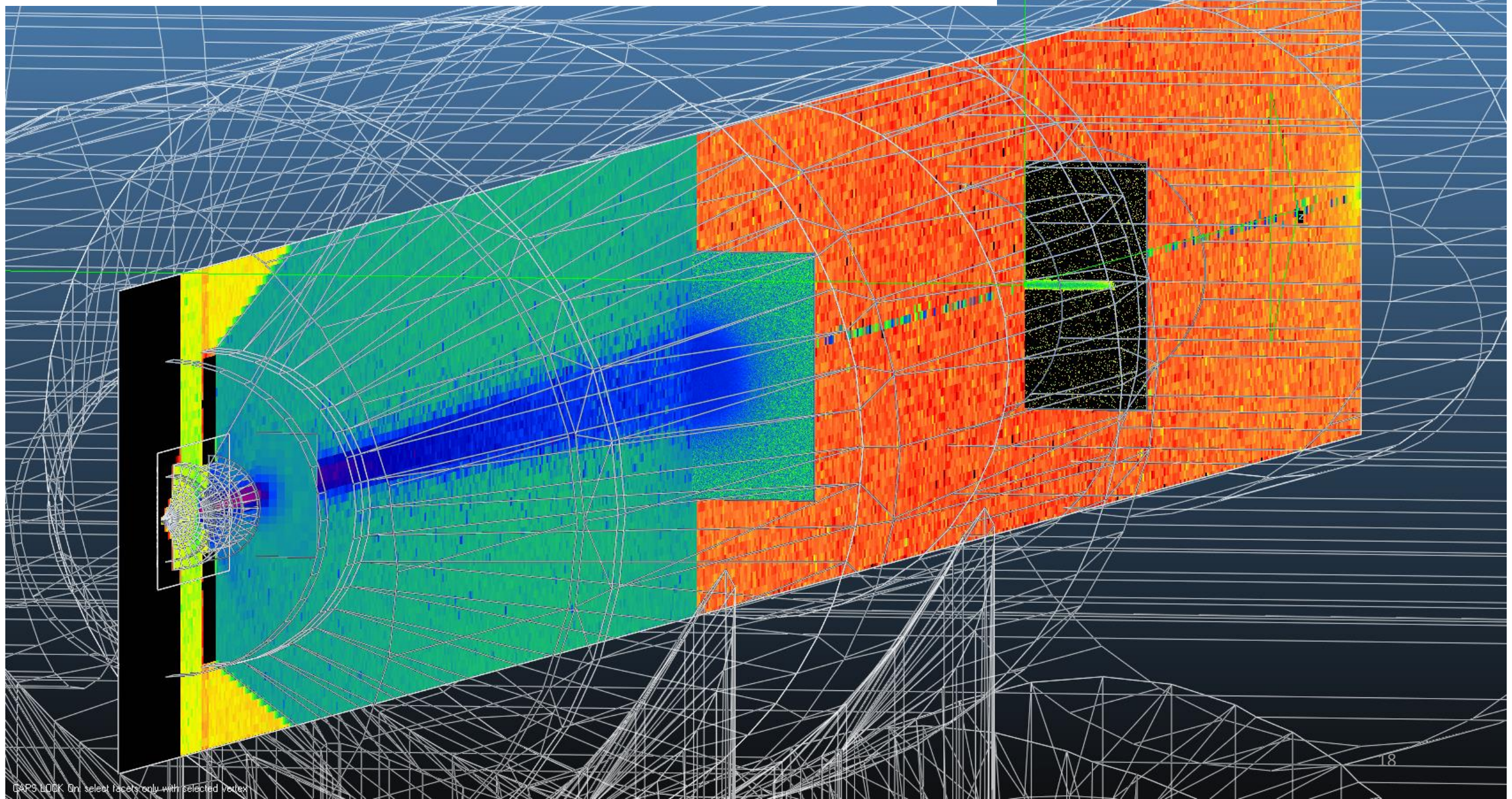
- Record
- Theta (grazing angle): 100 values from 0 to 0.15
- 50 values from 0.15 to PI/2
- Phi (azimuth with U): 1 values from -PI to +PI

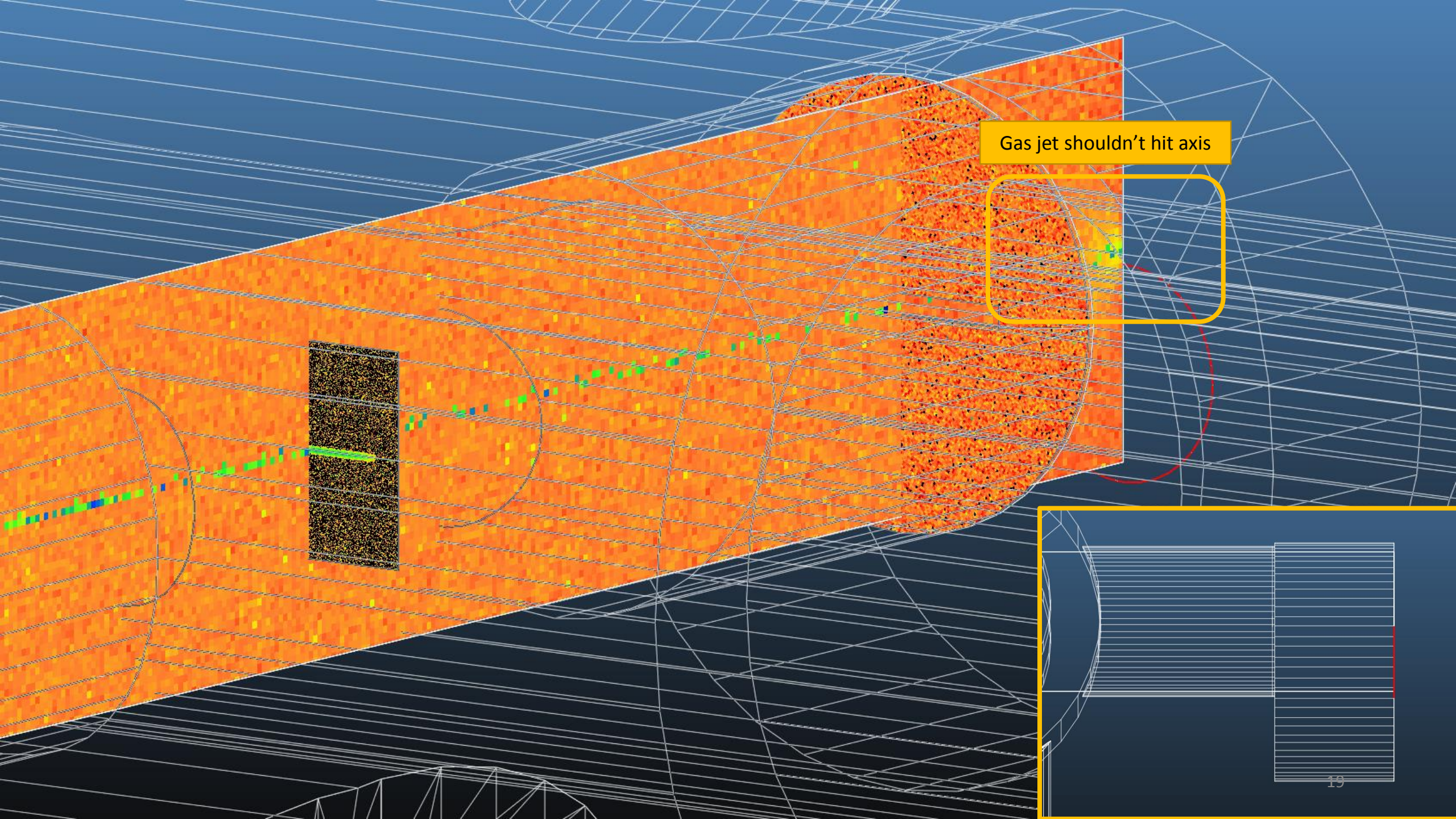
All selected facets have recorded angle maps (1.2 KB)

Copy Export to CSV Import CSV Release recorded

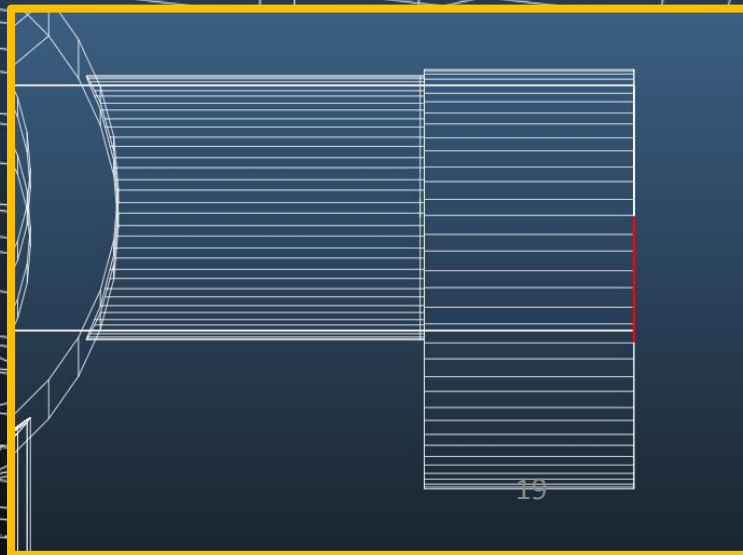


Iterative simulation 2nd step: use recorded distro for outgassing





Gas jet shouldn't hit axis

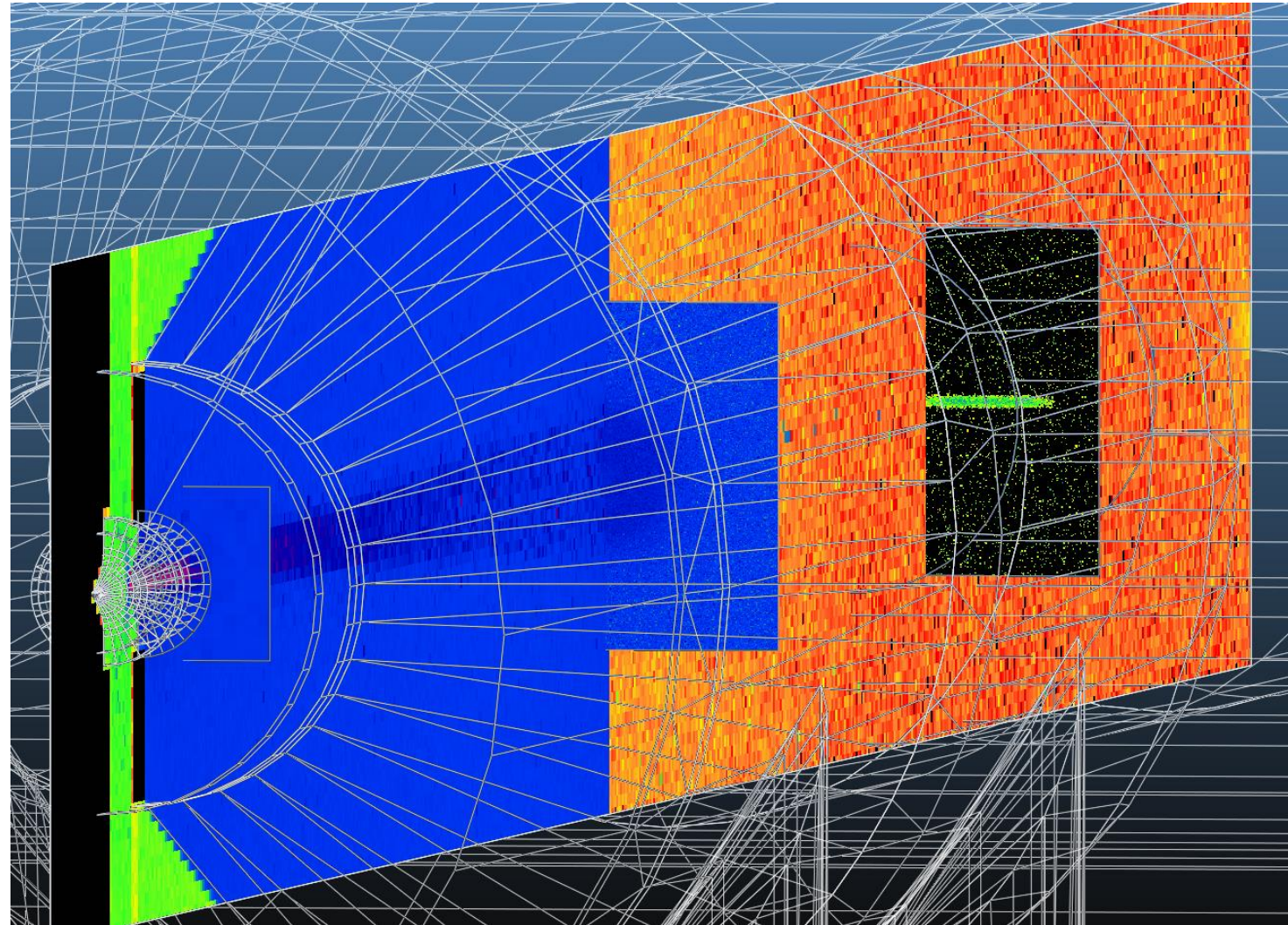


300l/s pump, 4x0.4mm skim3						
	SKim1-2	Skim2-cone	cone-skim3	IP	Dump	
100% opaque cone	8.7E-04	6.7E-04	3.3E-07	2.3E-09	4.7E-09	
			3.7E-07	2.5E-09	5.1E-09	
99.9% opaque cone	8.7E-04	6.3E-04	8.0E-06	8.7E-09	6.7E-09	<- seems probable, chosen as reference
99% opaque cone	7.7E-04	5.3E-04	6.0E-05	3.3E-08	1.3E-08	
99.9% op cone, increased skim2, pumps DN100 and 300l/s	2.6E-04	1.9E-04	2.9E-06	9.6E-09	5.8E-09	
			2.9E-06	7.6E-09	7.2E-09	
99.9% op cone, increased skim2, first two pumps DN63 w/ 170l/s	3.8E-04	3.2E-04	9.4E-06	2.0E-08	1.0E-08	
			9.6E-06	2.1E-08	1.2E-08	
99.9% op cone, increased skim2, first two pumps DN63 w/ 80l/s	6.0E-04	5.2E-04	2.8E-05	5.0E-08	2.6E-08	
			2.8E-05	5.4E-08	2.4E-08	
99.9% op cone, increased skim2, first two pumps DN63 w/ 170l/s + IP 170l/s	3.8E-04	3.0E-04	9.2E-06	3.0E-08	1.3E-08	
99.9% op cone, increased skim2, first two pumps DN63 w/ 80l/s + IP 80l/s	3.9E-04	3.2E-04	9.4E-06	3.4E-08	1.5E-08	
99.9% op cone, increased skim2, first two pumps DN63 w/ 80l/s + IP 80l/s, no imped.insert	3.9E-04	3.2E-04	9.3E-06	3.8E-08	2.0E-08	
op cone, increased skim2, pumps DN100 and 300l/s	2.6E-04	1.8E-04	4.8E-07	2.8E-09	5.7E-09	
			4.8E-07	3.5E-09	5.6E-09	
			4.8E-07	3.2E-09	5.4E-09	no imped. insert
			4.8E-07	1.6E-09	7.2E-09	backscattering reducer
op cone, increased skim2, first two pumps DN63 w/ 170l/s	4.0E-04	3.3E-04	1.0E-06	4.0E-09	4.4E-09	
			1.0E-06	4.7E-09	6.2E-09	
op cone, increased skim2, first two pumps DN63 w/ 80l/s	6.2E-04	5.6E-04	2.3E-06	7.2E-09	3.6E-09	
			2.2E-06	6.5E-09	6.5E-09	
op cone, increased skim2, first two pumps DN63 w/ 170l/s + IP 170l/s	4.0E-04	3.3E-04	1.1E-06	7.0E-09	6.4E-09	
			1.0E-06	6.5E-09	6.9E-09	
			1.0E-06	6.2E-09	6.7E-09	no imped. Insert
			1.0E-06	5.3E-09	7.2E-09	backscattering reducer
	4.0E-04	3.3E-04	1.1E-06	4.8E-09	5.6E-09	dn40 valves
			1.0E-06	6.0E-09	7.0E-09	dn40 valves
op cone, increased skim2, first two pumps DN63 w/ 80l/s + IP 80l/s	6.2E-04	5.6E-04	9.6E-07	1.0E-08	7.2E-09	
			1.0E-06	8.8E-09	7.8E-09	

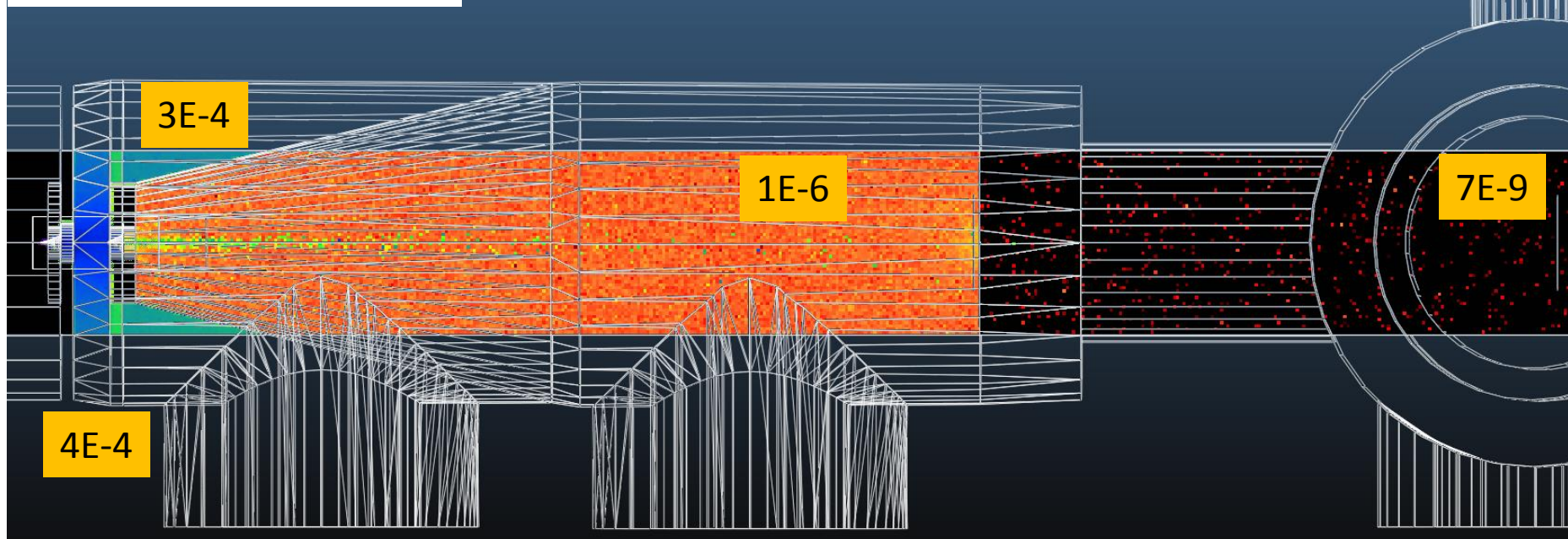
Gas jet -> 20mm: skimmer 2 and 3 need to be increased

Gas jet radius

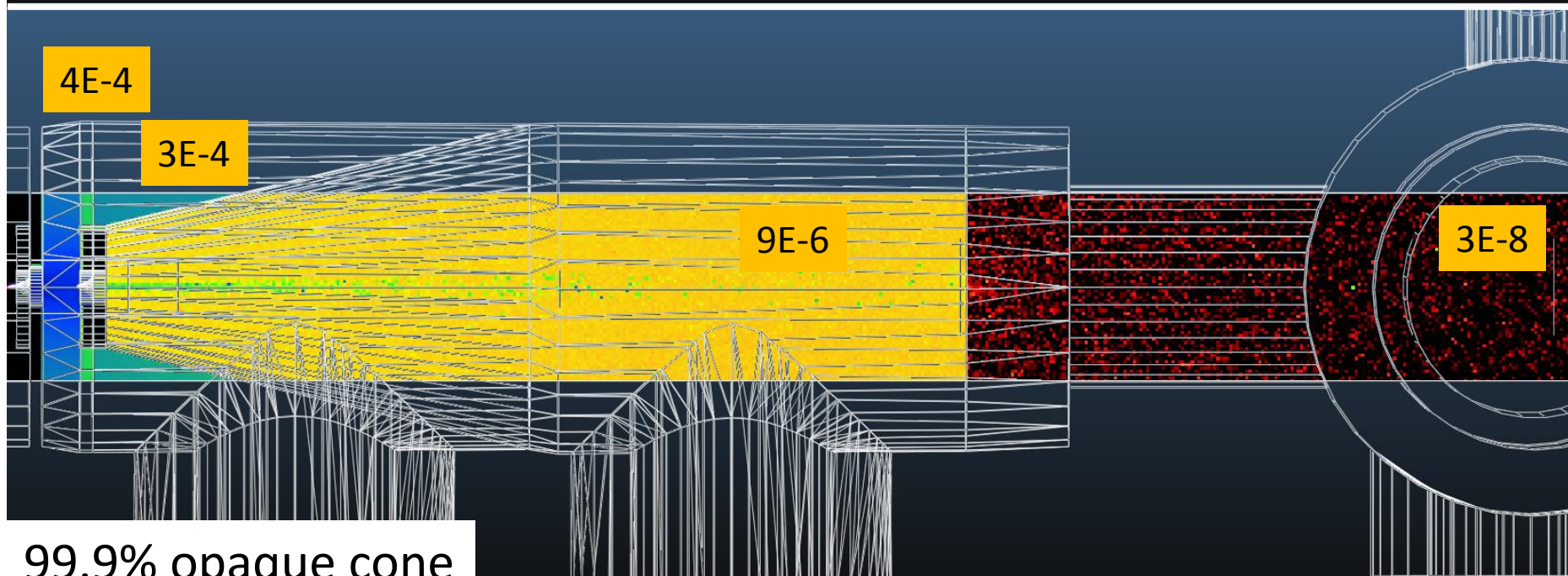
Skimmer1	Skimmer2	Skimmer3	IP	Dump entrance
0.00	0.2	3.99	6.43	8.26
		2.00	3.23	4.15
0.00	0.45	6.64	10.72	13.77
		6.60	10.65	13.68
		0.20	0.32	0.41



100% opaque cone



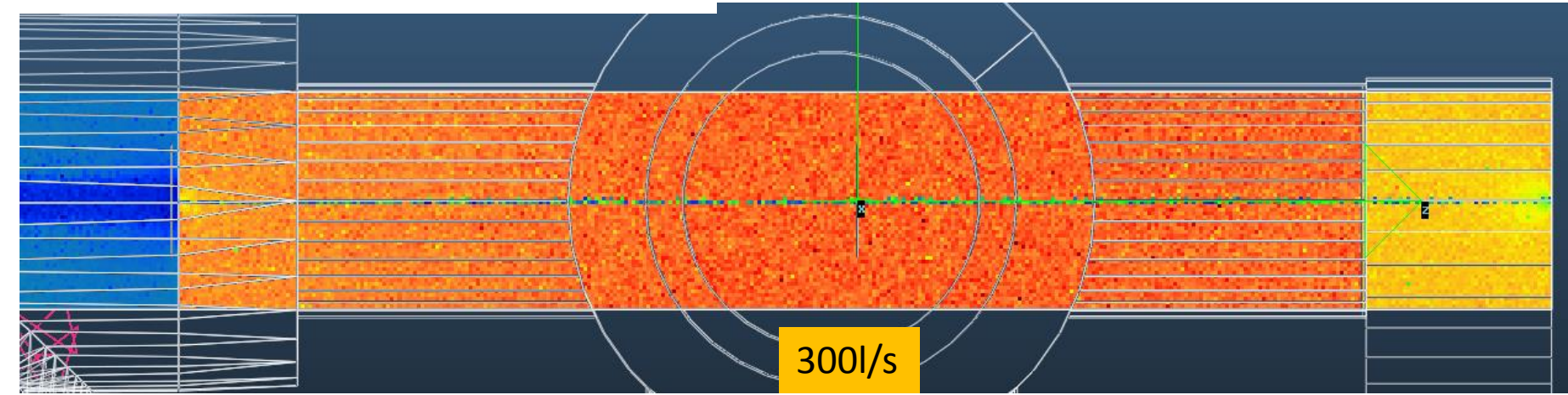
$6E-9$
DUMP



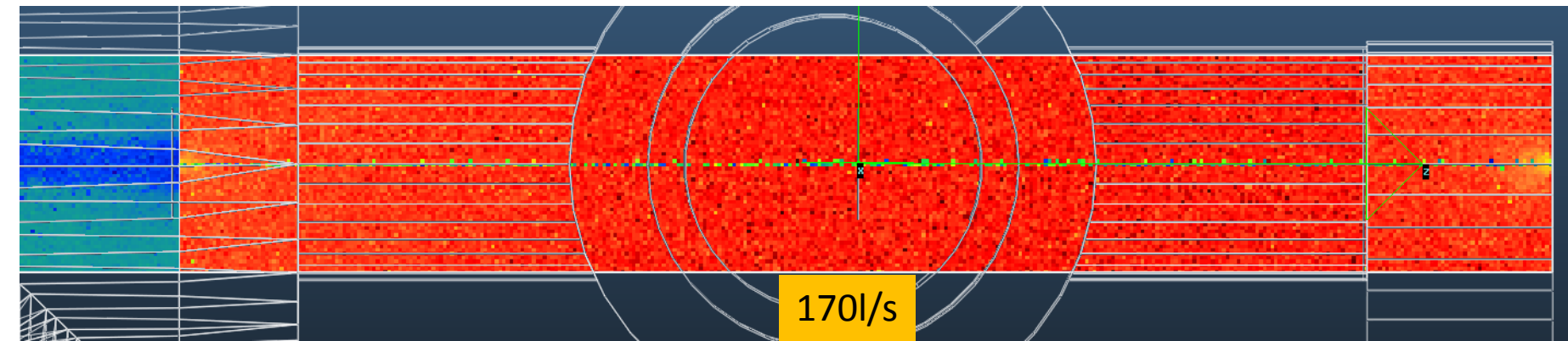
$1E-8$
DUMP

99.9% opaque cone

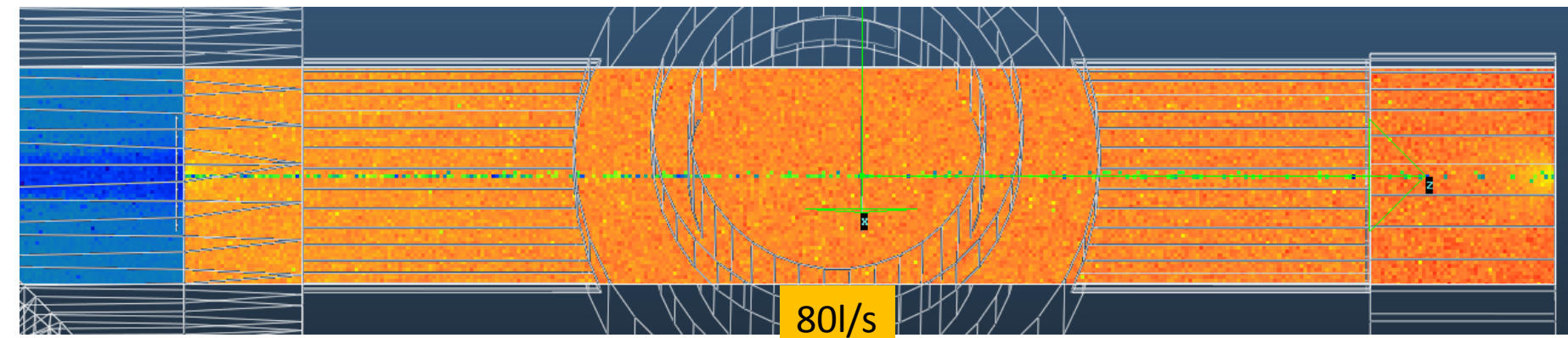
Role of backscattering reducer



Strong interaction chamber pump:
beneficial
(less gas load from dump area)



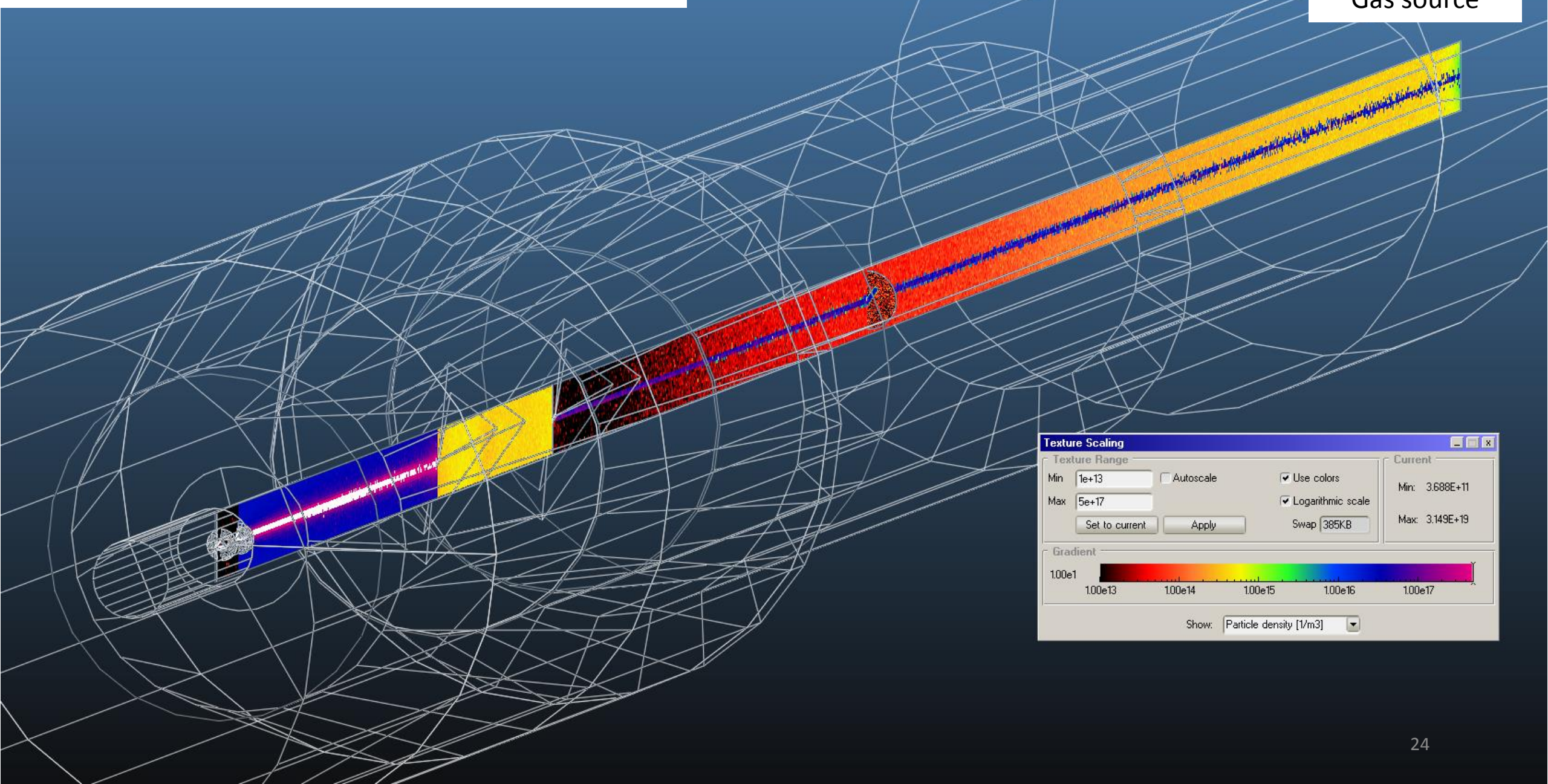
Reduced interaction chamber pump:
slightly beneficial



Weak interaction chamber pump:
slightly adverse
(less pumping from dump area)

Looking back to my slides from Darmstadt
Simplified geometry, strong pumping everywhere

Gas source



Texture Scaling

Texture Range

Min: Autoscale Use colors

Max: Logarithmic scale

Set to current Apply Swap

Current

Min: 3.688E+11

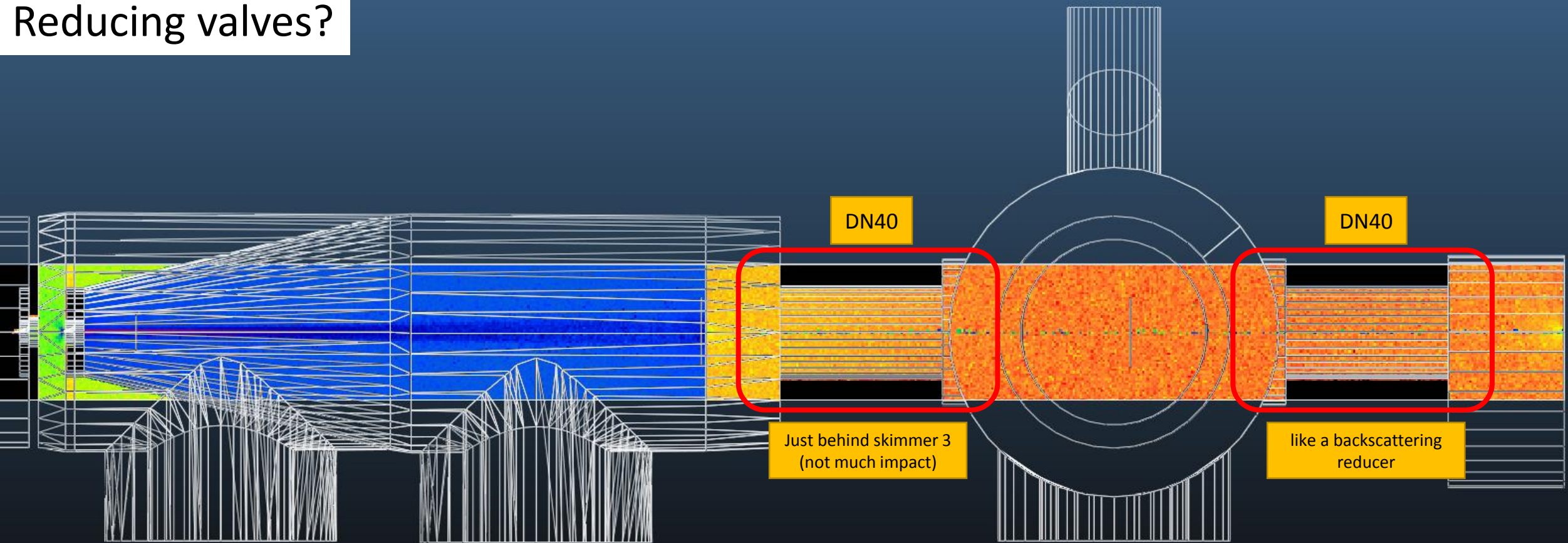
Max: 3.149E+19

Gradient

100e1 100e14 100e15 100e16 100e17

Show:

Reducing valves?



- Current Engineering Change Request: DN63 ports
- Using DN40 valves on the interaction chamber acts as a weak backscattering reducer
- Very slight increase of pressure in dump area, and reduction in interaction chamber
- Variations near statistical error, for simplicity: “no vacuum impact”

Cone: 100% opaque, Skimmer 2: 900um, Skimmer 3: 13.2/0.4mm

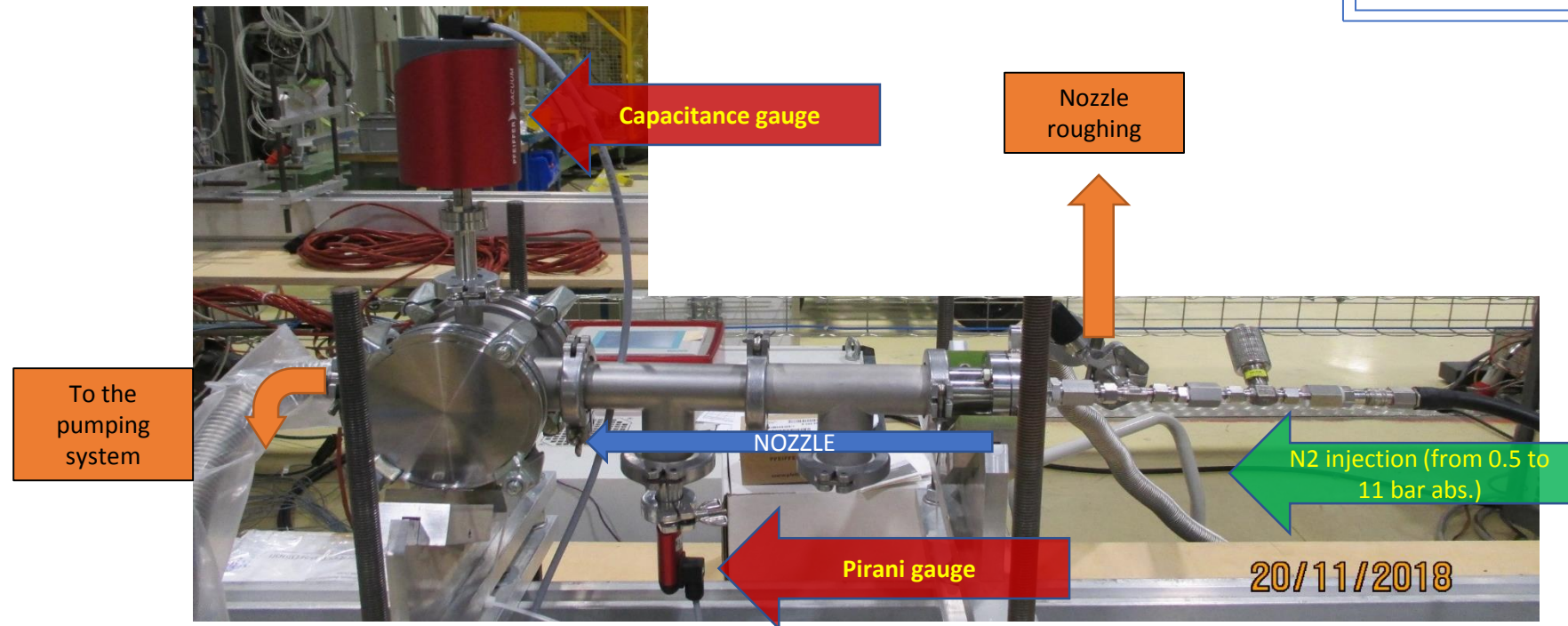
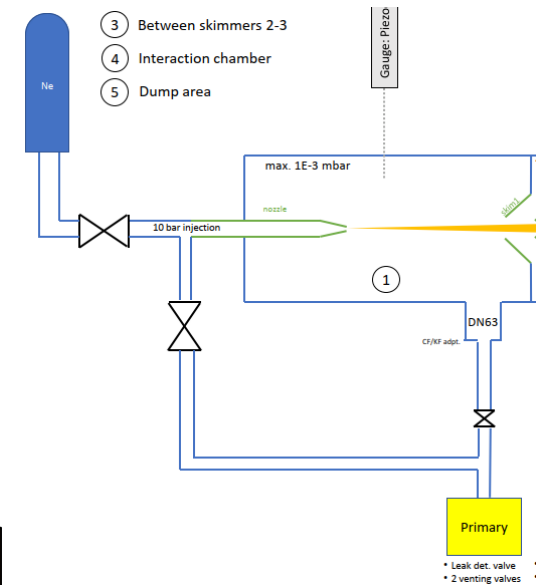
Case	Between skimmers 1-2	Between skimmers 2-3	Interaction chamber
1	250 l/s	250 l/s	250 l/s
	2E-4 mbar	5E-7 mbar	3E-9 mbar
2	170 l/s	170 l/s	250 l/s
	3E-4 mbar	1E-6 mbar	4E-9 mbar
3	80 l/s	80 l/s	250 l/s
	6E-4 mbar	2E-6 mbar	7E-9 mbar
4 / 5 / 6 / 7	170 l/s	170 l/s	170 l/s
	default / no impedance insertion / backscattering reducer / DN40 valves		
	3E-4 / 3E-4 / 3E-4 / 3E-4 mbar	1E-6 / 1E-6 / 1E-6 / 1E-6 mbar	7E-9 / 6E-9 / 5E-9 / 6E-9 mbar
8	80 l/s	80 l/s	80 l/s
	6E-4 mbar	2E-6 mbar	1E-8 mbar ²⁶

Conclusions (simulations)

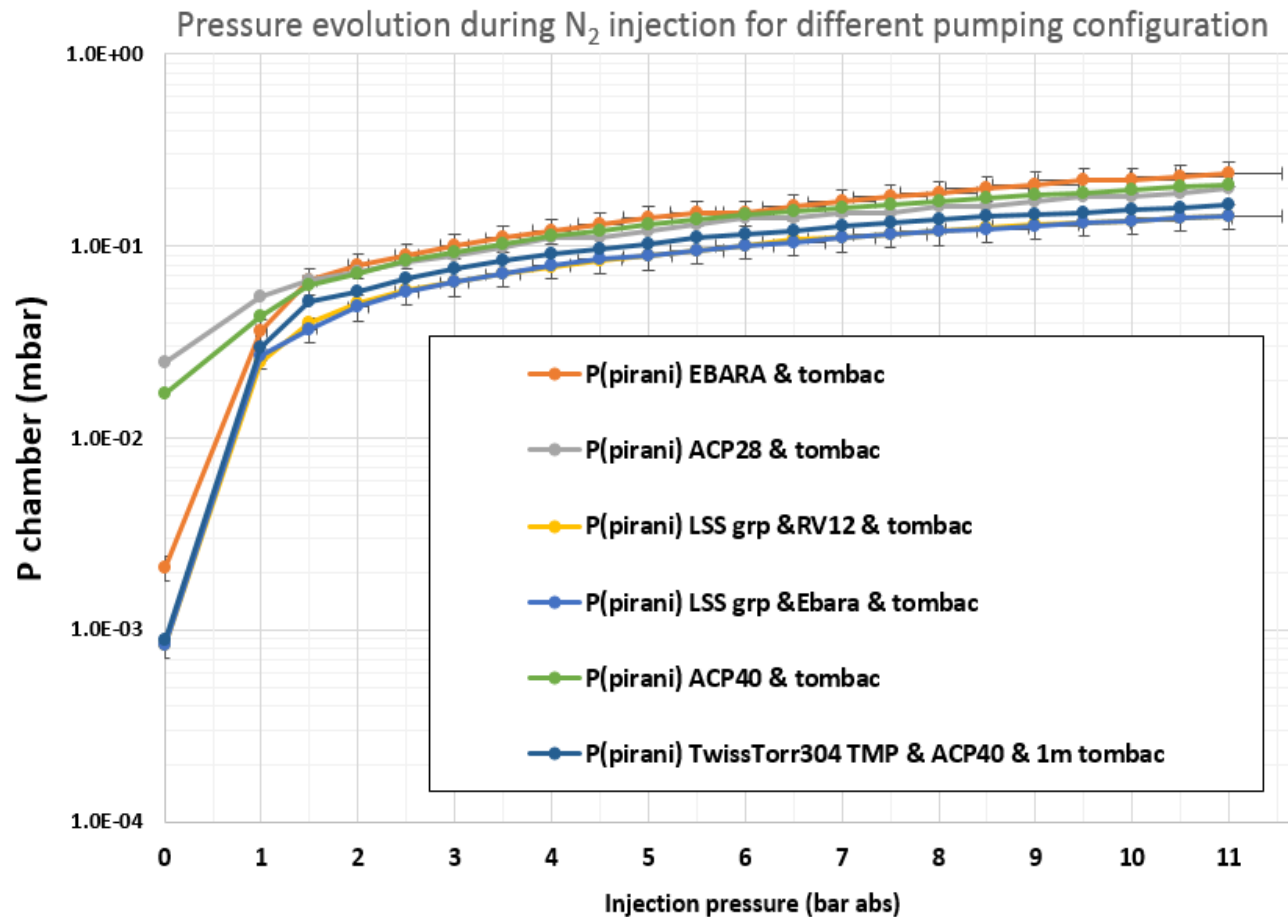
- Many free parameters when designing “v3” instrument
- Parameter change: mostly localized / predictable impact
- Strongly suggesting leak-tight cone separation
- DN63 pumping ports (with DN100 pumps) acceptable
- Backscattering reducer still effective, but no dramatic improvement
- Vacuum-wise OK to use DN40 valves on interaction chamber
- Sensitive compromise between gas jet density and IP background pressure to be found
- Nozzle chamber pumping still an issue
- Dump area optimization: to do
- LHC Neon impact / risk assesment: to do
- Operation interlock logic: to do

Dry pumps test for first vacuum chambers

- Nozzle is 30 μm diameter over 300 μm length
- Setup configuration:



Dry pumps test for first vacuum chambers



- Laminar flow through the nozzle.
- Measured with a leak detector (atm pressure side of nozzle)
 Q_{He} 2.5E-2 mbarl/s
- Calculated using gas viscosity for
 Q_{N_2} 1.5E-2 mbarl/s
- For every primary dry pump test, the measured pressure with an inlet pressure of 5 bar is between 10^{-1} and 1.5×10^{-1} mbar range.
- For a turbo molecular pumping group with any primary pumps (including rotary vane pump), the pressure remains in the same range.

**These primary pumps do not managed to absorb the gas flow coming from the nozzle.
 To be tests and confirm the impact of pressure low 10-1 mbar on the gas jet
 We could think to plan some test in Cockcroft institute beginning of next year.**

Beam Gas Curtain (BGC) Vacuum Controls Requirements

- **Cabling request (RQF0966942):**
 - Includes more than 33 cables
 - Still has to be modified according to last-minute changes (3x additional VPG missing)
 - OSVC signature awaiting...
- **UA43:**
 - Full Rack Re-arrangement and dedicated manpower for equipment installation, including inter-rack cabling, valve-interlock hardware configuration and Profibus network integration
 - 7x gauge controllers, 3x Valve controllers, 3x specific Valve-Interlock Crates and 5x dedicated Vacuum Pumping Group controllers
- **LHC Tunnel:**
 - 5x local crates and 3x Mini-Racks Installation for Vacuum Pumping Groups
 - Require EN-EL's intervention for electrical distribution (not informed yet, awaiting ECR...)
- **PLC/SCADA development:**
 - 3x Non-Standard Vacuum Pumping Groups requiring new specific PLC & SCADA development
 - Full database integration (Vac-DB)
 - New dedicated Control types, Synoptic integration (incl. Face-Plate) and Widget development required

Missing resources: Not in the LS2 baseline

Beam Gas Curtain (BGC) Vacuum Requirements

- **Final assembly & Commissioning of the system:**
 - The system shall be carefully tested in the lab to mimic all possible operation scenarios;
 - Calibration curves for different gases shall be carried out;
 - A detailed operation procedure shall be validated on the system and handled to VSC-ICM to be then integrated in the SCADA application;
 - Safety margin and a detailed risk analysis shall be defined and agreed.
- **LHC Tunnel -> Excepted installation during YETS 2021-2022(?):**
 - Full Support to the assembly in the tunnel;
 - Validation & commissioning of the vacuum system;
 - Commissioning of system.

Missing resources: Not in the LS2 baseline

Outlook: LHC Beam Vacuum simulation

- Fully detailed analysis of pressure profile on the LHC vacuum sector for different gases: need to finalize the BGC system to know the pressure 'escaping' from the interaction chamber.
- Impact of this gas on possible beam lifetime (nuclear cross section) and determine the quantity of gas condensed on the beam screen surface of the neighbourhood cryogenic stand alone magnets: planning of the thermal regeneration.

Outlook: BGC Jet Simulations

- Finalize “demonstrator instrument” design including pumps, which will be first installed in the LHC
- Model neighboring region (extract apertures from LHC layout DB)
- Model gas propagation from the instrument to the surroundings
- Draw conclusions on operation (Ne accumulation on beamscreen, etc.)

Conclusions

- Detailed simulation of the BGC is ongoing to optimize the design, pumping schemes, and aperture of the different chambers;
- TE-VSC needs to guarantee a proper gas density on the jet while keeping as low as possible the pressure in the LHC beam vacuum;
- The optimization of the BGC is crucial to have a system that would allow possible intervention during operation and maintenance during longer intervention of time;
- The first 'chambers' is still under study: Difficult to reach the required performance with 'standard' vacuum system.
- A detailed cost (hardware & resources) schedule review is missing for TE-VSC to properly guarantee the completion of the project